



STIC Search Report

EIC 2800

STIC Database Tracking Number: 155270

TO: Victor Mandala
Location: JEF-4C29
Art Unit : 2826
Thursday, June 16, 2005
Case Serial Number: 10/701,533

From: Jeff Harrison
Location: EIC 2800
JEF-4B68
Phone: 22511

Search Notes

Re: GaSb Substrate, Al semicond. middle layer, wider bandgap energy, photocathode, etc.

Please find attached the search history and the edited search results from patent and nonpatent literature, mostly Chemical Abstracts.

I put the more promising results at the top of the attached pile of results, but I suggest you browse all the results.

If you would like more searching on this case, or if you have questions or comments, please let me know.

Respectfully,
Jeff Harrison

L41 ANSWER 22 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 2001:406595 HCAPLUS

DN 135:186996

TI Noncryogenic quantum **detection** in the mid-IR using InAsSb **photovoltaic** structures

AU Rakovska, Anna; Berger, Vincent; Marcadet, Xavier; Glastre, Genevieve;
SO Proceedings of SPIE-The International Society for Optical Engineering
(2000), 4130(Infrared Technology and Applications XXVI), 537-546

AB A mid-IR **photovoltaic detector** using InAsSb as active material, grown by MBE on a GaSb substrate, is described. Quantum **detectors** can offer an alternative to thermal **detectors** (pyroelec. or resistive bolometers) for high temp. (near room temp.) operation. With a 9% Sb content, InAsSb is lattice matched to GaSb and provides a good material quality, with Shockley-Read lifetimes of the order of 200 ns as measured by photoconductive gain measurements as well as time resolved **photocond.** expts. The band gap of InAsSb corresponds to $\lambda = 5 \mu\text{m}$ at room temp. This makes InAsSb an ideal candidate for room temp. **detection** in the 3-5 μm atm. window. **Photovoltaic** structures are characterized by current-voltage characteristics as a function of temp. Using the absorption value obtained on the test samples, a **detectivity** of 7×10^9 Jones at 3.5 μm is estd. at temp. 250 K, which can easily be reached with Peltier cooling. Considering the **photovoltaic** spectrum, this leads to a NETD <80 mK.

IT Optical **detectors**

IT Band gap

(of noncryogenic quantum IR **detectors** using indium arsenide ntimonide **photovoltaic** structures)

IT 242808-30-6, Aluminum antimony gallium (Al0.47SbGa0.53)

(noncryogenic quantum **detection** in mid-IR using indium arsenide antimonide **photovoltaic** structures and barrier of)

RN 242808-30-6 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0.47:1:0.53)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| Ga | 0.53 | 7440-55-3 | |
| Sb | 1 | 7440-36-0 | |
| Al | 0.47 | 7429-90-5 | |

IT 110619-84-6, Antimony indium arsenide (Sb0.09InAs0.91)

(noncryogenic quantum **detection** in mid-IR using **photovoltaic** structures of)

RN 110619-84-6 HCAPLUS

CN Antimony indium arsenide (Sb0.09InAs0.91) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| In | 1 | 7440-74-6 | |
| As | 0.91 | 7440-38-2 | |
| Sb | 0.09 | 7440-36-0 | |

IT 12064-03-8

(substrate; noncryogenic quantum **detection** in mid-IR using indium arsenide antimonide **photovoltaic** structures on)

RN 12064-03-8 HCAPLUS

CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| Ga | 1 | 7440-55-3 | |
| Sb | 1 | 7440-36-0 | |

L41 ANSWER 25 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 2001:265766 HCAPLUS

DN 134:287644

ED Entered STN: 13 Apr 2001

TI Parallel cascade quantum well light emitting device

IN Yang, Rui Q.

PA Maxion Technologies, Inc., USA

| | PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|----|-----------------------------|----------|----------------------|-----------------------------------|----------------------|
| PI | WO 2001026192 US 6404791 | A1 B1 | 20010412 20020611 | WO 2000-US27586 US 2000-680317 | 20001006 20001006 |

PRAI US 1999-158403P P 19991007

AB Semiconductor light-emitting devices are described which comprise a plurality of essentially identical active regions, each such region comprising a plurality of spatially-coupled quantum wells; and injection regions between the active regions which form type II tunnel junctions between their adjacent active regions so that type II interband transitions occur in the active regions resulting in photon emissions. Each active regions may comprise multiple quantum well regions or finite superlattice regions to improve carrier injection efficiency and enhance optical gain. By using type II tunnel junction in the injection regions, carriers can be reused through a spatial interband coupling after an interband transition for photon emission, leading to the realization of interband cascade configuration under an appropriate bias.

IT 12064-03-8, Gallium antimonide 25152-52-7, Aluminum antimonide 51680-21-8, Aluminum gallium antimonide arsenide 106603-88-7, Aluminum gallium antimonide 106603-91-2, Indium arsenide antimonide (parallel cascade quantum well light-emitting devices)

RN 12064-03-8 HCAPLUS

CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Ga | 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |

RN 25152-52-7 HCAPLUS

CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

RN 51680-21-8 HCAPLUS

CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

RN 106603-88-7 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0-1:1:0-1) (9CI)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Ga | 0 - 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| In | 1 | 7440-74-6 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

L41 ANSWER 38 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1998:180599 HCAPLUS

DN 128:224868

TI Semiconductor structures having electrically insulating and conducting portions formed from an AlSb-alloy layer

IN Spahn, Olga B.; Lear, Kevin L.

PA Sandia Corp., USA

AB The semiconductor structure comprises a plurality of semiconductor layers formed on a substrate including ≥ 1 layer of an AlSb alloy, with at least a part of the AlSb alloy layer being chem. converted by oxidn. to form superimposed elec. insulating and elec. conducting portions. The elec. insulating portion formed from the AlSb alloy layer comprises an oxide of Al (e.g. Al₂O₃), while the elec. conducting portion comprises Sb. A lateral oxidn. process gives the superimposed insulating and conducting portions below monocryst. semiconductor layers for forming many different types of semiconductor structures having particular utility for optoelectronic devices such as LEDs, edge-emitting lasers, vertical-cavity surface-emitting lasers, photodetectors and optical modulators (waveguide and surface normal), and for electronic devices such as heterojunction bipolar transistors, field-effect transistors, and quantum-effect devices. The invention is expected to be particularly useful for forming light-emitting devices for use in the 1.3-1.6 μm wavelength range, with the AlSb alloy layer acting to define an active region of the device and to effectively channel an elec. current for efficient light generation.

IT 25152-52-7 51680-21-8, Aluminum antimony gallium arsenide 189698-35-9
(semiconductor structures having elec. insulating and conducting portions formed from AlSb-alloy layers)

RN 25152-52-7 HCAPLUS

CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------|-----------------|
| | | | Registry Number |
| <hr/> | | | |
| Sb | 1 | | 7440-36-0 |
| Al | 1 | | 7429-90-5 |

RN 51680-21-8 HCAPLUS

CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------|-----------------|
| | | | Registry Number |
| <hr/> | | | |
| Ga | 0 - 1 | | 7440-55-3 |
| As | 0 - 1 | | 7440-38-2 |
| Sb | 0 - 1 | | 7440-36-0 |
| Al | 0 - 1 | | 7429-90-5 |

RN 189698-35-9 HCAPLUS

CN Aluminum, compd. with antimony and gallium (1:1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------|-----------------|
| | | | Registry Number |
| <hr/> | | | |
| Ga | 1 | | 7440-55-3 |
| Sb | 1 | | 7440-36-0 |
| Al | 1 | | 7429-90-5 |

IT 12064-03-8

(substrate; semiconductor structures having elec. insulating and conducting portions formed from AlSb-alloy layers on)

RN 12064-03-8 HCAPLUS

CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------|-----------------|
| | | | Registry Number |
| <hr/> | | | |
| Ga | 1 | | 7440-55-3 |
| Sb | 1 | | 7440-36-0 |

US 5726462

3/10/98

L41 ANSWER 43 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1996:543949 HCAPLUS

DN 125:183420

ED Entered STN: 12 Sep 1996

TI Semiconductor **photoelectric cathodes** and devices with the **cathodes**

IN Futahashi, Tokuaki

PA Hamamatsu Photonics Kk, Japan

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|---------------------|------|----------|-----------------|----------|
| JP 08153462 | A2 | 19960611 | JP 1994-292983 | 19941128 |
| JP 3433538 | B2 | 20030804 | | |
| PRAI JP 1994-292983 | | 19941128 | | |

AB The **cathodes**, which generate electron upon light absorption, and emit the electron by accelerating through external field, contain p-type light-absorbing 1st semiconductor layers (e.g., InGaAs) on semiconductor substrates (e.g., InP), p-type 2nd semiconductor layers (e.g., InP), Schottky electrodes in Schottky contact with, and covering part or the whole of the 2nd semiconductor layers, and having openings, 3rd semiconductor (active) layers having smaller work function than that of the 2nd semiconductor layers, and formed in the openings, and p-type semiconductors (e.g., InP) (channel lattices) buried in the 2nd semiconductor layers and below the Schottky electrodes, and having greater impurity concn. than that of the 2nd semiconductor layers.

IT **Photoelectric** devices(laminated **cathodes** and devices contg. them)IT **Cathodes**

(photoelec.; laminated semiconductor devices contg.)

IT 12064-03-8, Gallium antimonide 106603-88-7, Aluminum gallium antimonide 106603-91-2, Antimony indium arsenide
 RL: DEV (Device component use); USES (Uses)
 (semiconductor **photoelec.** **cathodes** and devices with the **cathodes**)

RN 12064-03-8 HCAPLUS

CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |

RN 106603-88-7 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0-1:1:0-1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0 - 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

L41 ANSWER 47 OF 66 HCPLUS COPYRIGHT 2005 ACS on STN

AN 1994:711117 HCPLUS
DN 121:311117
ED Entered STN: 24 Dec 1994
TI Tunable IR-diode lasers based on the A3B5 solid solution for the spectral range 2-4 μ m
AU Yakovlev, Yu. P.; Baranov, A. N.; Imenkov, A. N.; Popov, A. A.; Sherstnev, V. V.
SO Proceedings of SPIE-The International Society for Optical Engineering (1994), 2112(TUNABLE DIODE LASER SPECTROSCOPY, LIDAR, AND DIAL TECHNIQUES FOR ENVIRONMENTAL AND INDUSTRIAL MEASUREMENTS), 50-61
CODEN: PSISDG; ISSN: 0277-786X
LA English
AB The structures and electroluminescence characteristics of new 2 types of single mode A3B5 semiconductor tunable lasers in the 1.8-3.9 μ m spectral range were demonstrated. The 1st type of tunable diode laser based on quaternary solid solns. GaInAsSb and GaAlAsSb lattice matched to GaSb substrate covers 1.8-2.4 μ m spectral range. Such tunable 1.8-2.4 μ m lasers have single mode or quasi-single mode operation in the wide temp. range from 1.6 to 300K. The 2nd type of tunable diode laser based on multiple component InPAsSb/InAsSb lattice matched or mismatched to InAs substrate covers 2.8-3.9 μ m spectral range, which was not available for diode laser spectroscopy until now. Such tunable 2.8-3.9 μ m lasers have continuous-wave single mode operation up to 100K and pulse operation up to 180K. These lasers can be the key devices for diode laser spectroscopy and sensitive **detection** of pollutants.

IT 12064-03-8, Gallium antimonide (GaSb) 51680-21-8,
Aluminum gallium antimonide arsenide 106603-91-2, Antimony
indium arsenide (SbInAs)
(tunable IR-diode lasers based on A3B5 solid soln. for spectral range
2-4 μm)

EN 12006-1:2013-08 - IEC60068-2-27:2008

| RN 12064-03-8 HCAPLUS | | | |
|--|-------|-----------|-----------------|
| CN Antimony, compd. with gallium (1:1) (9CI) (CA IN) | | | |
| Component | Ratio | Component | Registry Number |
| | | | |
| Ga | 1 | | 7440-55-3 |
| Sb | 1 | | 7440-36-0 |

BN 51680-21-8 HCAPLUS

RN 5180-21-6 HCAPPES
CN Aluminum antimony gallium arsenide ((Al_xGa)_y(Sb_zAs)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| In | 1 | 7440-74-6 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

L41 ANSWER 45 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1996:469973 HCAPLUS
 DN 125:127350
 ED Entered STN: 09 Aug 1996
 TI Infrared **detector** element substrate with superlattice layers
 IN Lee, Myung B.
 PA Grumman Aerospace Corp., USA

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|---------------------|------|----------|-----------------|----------|
| PI US 5536948 | A | 19960716 | US 1994-294635 | 19940823 |
| PRAI US 1994-294635 | | | 19940823 | |

AB A substrate upon which IR elements are formed has a cryst. base layer, preferably comprised of silicon; a first strain superlattice layer formed of a plurality of pairs of gallium antimonide and indium arsenide antimonide sublayers upon the base layer; and a first matched superlattice layer formed of a plurality of pairs of gallium antimonide and aluminum antimonide sublayers upon the strain superlattice layer. The strain superlattice layer and the matched superlattice layer mitigate defect propagation from the base layer to the IR **detector** elements. Optionally, a plurality of addnl. or second strain and matched superlattice layers may be formed in an alternating layer configuration upon the first matched superlattice layer so as to achieve enhanced defect filtering.

ST IR **detector** substrate superlattice layer

IT Optical **detectors**

(IR, IR **detector** element substrates with superlattice layers)

IT 12064-03-8, Gallium antimonide **25152-52-7**, Aluminum antimonide **106603-91-2**, Antimony indium arsenide ((Sb,As)In)

RL: DEV (Device component use); USES (Uses)

(IR **detector** element substrates with superlattice layers)

IT **25152-52-7**, Aluminum antimonide **106603-91-2**, Antimony indium arsenide ((Sb,As)In)

RL: DEV (Device component use); USES (Uses)

(IR **detector** element substrates with superlattice layers)

RN 25152-52-7 HCAPLUS

CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

FILE 'REGISTRY' ENTERED AT 12:31:56 ON 16 JUN 2005
L1 166 S GA.SB/MF OR GA SB/ELF OR GALLIUM ANTIMONIDE
L2 158 S AS.IN.SB/MF OR AS IN SB/ELF OR ARSENIC
 INDIUM ANTIMONIDE OR INDIUM ARSENIC ANTIMONIDE
L3 118 S AL.GA.SB/MF OR AL GA SB/MF OR ALUMINUM
 GALLIUM ANTIMONIDE OR GALLIUM ALUMINUM ANTIMONIDE
L4 51 S ALUMINUM/CN OR AL/MF

FILE 'HCAPLUS' ENTERED AT 12:35:40 ON 16 JUN 2005
L5 460 S L1(L) (SUBSTRATE OR BASE OR PLATE OR SUPPORT)
L6 6 S L2(L) ?ABSOR?
L7 0 S L2(L) (ARC OR BARC OR ANTIREFLECT? OR MATTE OR ANTI REFLECT#####)
L8 10004 S L4(L) SEMICOND#####
L9 1986 S L4(L) (INTERMEDIATE OR INTER OR INTERPOS#### OR INTERLAYER?)
L10 624 S L4(L) (FILM OR LAYER) AND L4(L) (BETWEEN OR MIDDLE OR CENTER)
L11 112 S L3(L) (FILM OR INTERPOS? OR INTER OR
 INTERLAYER? OR LAYER? OR SUBLAYER? OR UNDERLAYER? OR OVERLAYER?)
L12 32 S L3(L) (ENERGY OR WIDE OR WIDEGAP OR
 WIDEBAND OR WIDE OR BANDGAP? OR BAND GAP#####)
L13 1 S US20040089860/PN
L14 324 S 51680-21-8,

FILE 'REGISTRY' ENTERED AT 12:45:21 ON 16 JUN 2005
L15 1 S 25152-52-7/RN

FILE 'HCAPLUS' ENTERED AT 12:45:22 ON 16 JUN 2005
L16 2711 S L15
L17 296 S 106603-91-2,

FILE 'REGISTRY' ENTERED AT 12:45:50 ON 16 JUN 2005
L18 1 S 25152-52-7/RN

FILE 'HCAPLUS' ENTERED AT 12:45:50 ON 16 JUN 2005
L19 2711 S L18
L20 29 S L5 AND (L8 OR L9 OR L10 OR L11 OR L12)
L21 0 S L10 AND (L11 OR L12)
L22 3 S L14 AND L16 AND L17 AND L19
L23 SEL PLU=ON L13 1- NCL IC FTERM : 5 TERMS
L24 47 S L1 AND L2 AND L3
L25 541 S L23
L26 1 S (L14 AND L17 AND L16) AND L25
L27 1 S L14 AND L16 AND L19 AND L25
L28 1 S L16 AND L17 AND L19 AND L25
L29 3 S L14 AND L16 AND L17
L30 3 S L14 AND L16 AND L17
L31 18 S L14 AND L16 AND L19
L32 3 S L14 AND L17 AND L19
L33 28 S L15 AND L17 AND L19
L34 139 S L6 OR L12 OR L13 OR L20 OR L22 OR L24 OR
 (L26 OR L27 OR L28 OR L29 OR L30 OR L31 OR L32 OR L33)
L35 4 S L24 AND WIDE#####
L36 11 S L34 AND WIDE#####
L37 30 S L34 AND ENERGY(4A) (GAP OR BAND OR BANDGAP)
L38 21 S L34 AND ?DETECT?
L39 31 S L34 AND PHOTO#####
L40 5 S L34 AND ?CATHODE?
L41 66 S L6 OR L22 OR (L26 OR L27 OR L28 OR L29 OR
 L30) OR L32 OR (L35 OR L36 OR L37 OR L38 OR L39 OR L40)
L42 101014 S PHOTODETECT? OR PHOTOCATH? OR PHOTOSENS?
L43 56 S (L25 OR L26 OR L27 OR L28 OR L29 OR L30 OR
 L31 OR L32 OR L33 OR L34) AND L42
L44 51 S L43 NOT L41
L45 3 S L44 AND WIDE?
L46 3 S L44 AND LARGER?

L41 ANSWER 28 OF 66 HCPLUS COPYRIGHT 2005 ACS on STN

AN 2000:334161 DN 133:24422

TI Mid-IR InAsSb photovoltaic detectors

AU Rakovska, Anna; Berger, Vincent; Marcadet, Xavier; Glastre, Genevieve; Vinter, Borge; Bouzehouane, K.; Kaplan, Daniel; Oksehendler, T.

SO Proceedings of SPIE-The International Society for Optical Engineering (2000), 3948(Photodetectors: Materials and Devices V), 55-62

AB We describe a mid-IR photovoltaic detector using InAsSb as active material, grown by MBE on a GaSb substrate. The purpose of this study is to show that quantum detectors can offer an alternative to thermal detectors for high temp. operation. With a 9% Sb content, InAsSb is lattice matched to GaSb and thus provides an excellent material quality, with Shokley-Read lifetimes of the order of 200 ns as measured by photoconductive gain measurements as well as time resolved photocond. expts. The band gap of InAsSb corresponds to a wavelengths as well as time resolved photocond. expts. The band gap of InAsSb corresponds to a wavelength of 5 μ m at room temp. This makes InAsSb an ideal candidate for room temp. detection in the 3-5 μ m atm. window. Photovoltaic structures are characterized by current voltage characteristics as a function of temp. Using the absorption value obtained on the test samples, a detectivity of 7×10^9 Jones can be obtained at a temp. of 250 K, which can easily be reached with Peltier cooling. This leads to a NETD lower than 80 mK.

IT 12064-03-8, Gallium antimonide 106603-91-2, Antimony indium arsenide ((Sb,As)In) 110619-84-6, Antimony indium arsenide (Sb0.09InAs0.91) 117944-40-8, Aluminum gallium antimonide (Al0.5Ga0.5Sb) 242808-30-6, Aluminum, compd. with antimony and gallium (0.47:1:0.53)

(mid-IR InAsSb photovoltaic detectors)

RN 12064-03-8 HCPLUS

CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |

RN 106603-91-2 HCPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

RN 110619-84-6 HCPLUS

CN Antimony indium arsenide (Sb0.09InAs0.91) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0.91 | 7440-38-2 |
| Sb | 0.09 | 7440-36-0 |

RN 117944-40-8 HCPLUS

CN Aluminum, compd. with antimony and gallium (0.5:1:0.5)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0.5 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.5 | 7429-90-5 |

RN 242808-30-6 HCPLUS

CN Aluminum, compd. with antimony and gallium (0.47:1:0.53) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0.53 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.47 | 7429-90-5 |

Mid-IR InAsSb photovoltaic detectors

Anna Rakovska, Vincent Berger, Xavier Marcadet, Geneviève Glastre, Borge Vinter
Laboratoire Central de Recherches THOMSON-CSF, Domaine de Corbeville, F-91404 ORSAY,
FRANCE
K. Bouzehouane^{a)}, D. Kaplan, T. Oksehendler
ALLIAGE, X Pole, Ecole Polytechnique, F-91128 PALAISEAU, FRANCE

ABSTRACT

We describe a mid-IR photovoltaic detector using InAsSb as active material, grown by MBE on a GaSb substrate. The purpose of this study is to show that quantum detectors can offer an alternative to thermal detectors (pyroelectric or resistive bolometers) for high temperature (near room temperature) operation. With a 9% Sb content, InAsSb is lattice matched to GaSb and thus provides an excellent material quality, with Shockley-Read lifetimes of the order of 200 ns as measured by photoconductive gain measurements as well as time resolved photoconductivity experiments. The band gap of InAsSb corresponds to a wavelength of 5 microns at room temperature. This makes InAsSb an ideal candidate for room temperature detection in the 3-5 microns atmospheric window. Photovoltaic structures are characterized by current voltage characteristics as a function of temperature. Using the absorption value obtained on the test samples, a detectivity of 7×10^9 Jones can be obtained at a temperature of 250 K, which can easily be reached with Peltier cooling. This leads to a NETD lower than 80 mK.

Keywords: InAsSb, IR-detector, lifetime, GaSb, MBE

1. INTRODUCTION

Antimonide based materials have a strong potential for the development of mid infrared devices such as lasers or detectors operating between 2 and 5 μm . Applications in this spectral range are found in various domains such as pollutant detection, infrared thermal imaging, lidars or optical countermeasures. The knowledge of the material's intrinsic characteristics such as band gap and band offsets is critical for the design of these devices, and their performances depend directly on the effective lifetime. In the case of $\text{InAs}_{1-x}\text{Sb}_{x-0.09}$ nearly lattice matched to GaSb, the band gap around 5 μm and the small effective mass lead to an intrinsic carrier density of the order of a few 10^{15} cm^{-3} at room temperature. This typical carrier density is sufficiently low for neglecting intrinsic Auger recombination¹. At low optical excitation, the effective lifetime is likely to be dominated by nonradiative Shockley-Read recombination, and is therefore a direct indication of the material quality.

We present first band gap and lifetime measurements on a series of test samples of MBE grown InAsSb closely lattice matched to a GaSb substrate. The gap is deduced from absorption, photoluminescence and photoconductivity spectra. Photoconductivity gain measurements and time resolved photoconductivity lead to the effective lifetime determination.

Based on a similar structure as the test samples, an $\text{InAs}_{0.91}\text{Sb}_{0.09}$ p-i-n photovoltaic mid infrared detector is reported. It has been characterized by I(V) measurements as a function of temperature. The mechanism limiting the detectors performances has been established.

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The paper is structured as follows. Section 2 gives an overview of the growth conditions and the description of the test sample structure. Section 3 focuses on the spectral characterization, yielding the room temperature gap around the lattice matching Sb concentration in InAsSb. In section 4 lifetime measurements by two different methods are presented and the consequences on an InAsSb based detector explained. Finally, the characteristics of a photovoltaic detector are shown in section 5.

2. PHOTCONDUCTIVE SAMPLE DESCRIPTION

2.1. MBE growth

The samples were grown in a RIBER-32 MBE system with a Reflection High Energy Electron Diffraction (RHEED) facility. The As flux is calibrated from the (2x4) to (4x2) surface reconstruction transition on a GaAs (100) substrate² whereas Sb-limited RHEED oscillations on GaSb substrates are used to accurately determine the Sb flux. High Resolution X-Ray Diffraction (HXRD) measurements in the vicinity of the (004) reflection were used for composition determination, taking into account strain effects. The $\text{InAs}_{1-x}\text{Sb}_x$ layers were found to be lattice matched for $x=0.089$.

2.2. Test sample structure

The band structure of a typical photoconductive sample in thermal equilibrium at room temperature is shown in figure 1. This calculation is based on the numerical resolution of Poisson's equation, taking into account the Fermi distribution of the carriers. Band offset values, electron and hole masses and other physical parameters were taken from the literature³⁻⁶ or extracted from photoconductivity and photoluminescence measurements. When the necessary parameters for ternary or quaternary compounds were not directly available, linear interpolation was used. The boundary conditions at the free surface were set by positioning the bands relative to the Fermi level of a bulk material of the same doping. This choice does not take into account Fermi level pinning at the free surface. Since its value is not known in these materials, we have not tried to improve the model on this point.

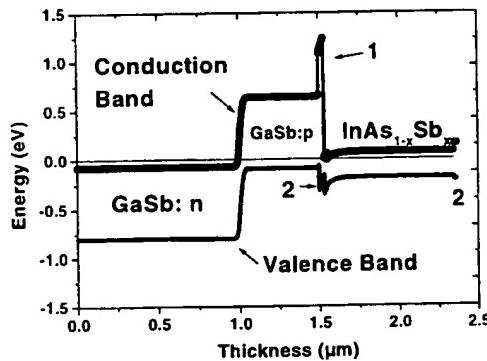


Figure 1. Band structure simulation of a test sample at 300 K. The Fermi level is the zero energy. A n.i.d. GaSb p buffer is grown, followed by a 30 nm $\text{Al}_{0.47}\text{Ga}_{0.53}\text{Sb}$ confining barrier for electrons (1), and a 18 nm $\text{In}_{0.85}\text{Al}_{0.15}\text{As}_{0.9}\text{Sb}_{0.1}$ barrier for holes (2). The lattice matching condition for $\text{InAs}_{1-x}\text{Sb}_x$ is obtained for $x=0.089$. The finishing layer is also $\text{In}_{0.85}\text{Al}_{0.15}\text{As}_{0.9}\text{Sb}_{0.1}$ (2).

The structure was grown on a n.i.d. p-type 0.5 μm thick GaSb buffer. The GaSb/ $\text{InAs}_{1-x}\text{Sb}_x$ interface is known to be semimetallic⁵ causing electron transfer into the $\text{InAs}_{1-x}\text{Sb}_x$ layer, from the valence band of GaSb. This might disturb some characterization measurements such as photoluminescence or photoconductivity. In order to reduce the carrier population at the semimetallic interface, a barrier made of 30 nm of $\text{Al}_{0.47}\text{Ga}_{0.53}\text{Sb}$ and 18 nm of $\text{In}_{0.85}\text{Al}_{0.15}\text{As}_{0.9}\text{Sb}_{0.1}$ was grown between the $\text{InAs}_{1-x}\text{Sb}_x$ layer and the GaSb buffer.

2.3. Contacting

For the purpose of photoconductivity measurements, 3 mm long TiPtAu contacts were evaporated at a distance of 0.291 mm from each other on the epitaxial layer, after a deoxidation step. No annealing was performed. The contact resistivity measured using the Transmission Line Model (TLM) was established to be of the order of $7 \times 10^{-5} \Omega\cdot\text{cm}^2$.

3. OPTICAL SPECTRAL CHARACTERIZATIONS

The purpose of this section is to provide a full spectral characterization of this material system at room temperature and demonstrate its suitability for the use in mid-IR detection. Absorption, photoconductivity and photoluminescence experiments were carried out, compared and analyzed in the light of theoretical simulations.

3.1. InAsSb absorption: measurement and calculation

A transmission measurement was performed on a sample with a Sb content of 0.09, using a MagnaIR 860 Nicolet Fourier Transform spectrometer and its internal black body source. The absorption was deduced by normalizing the transmission of the sample with a bare substrate transmission spectrum. The resulting spectrum is in remarkably good agreement with the theoretical simulation of the absorption of a 800 nm InAsSb layer at room temperature (figure 2), based on a 2X9-band $\mathbf{k}\cdot\mathbf{p}$ calculation. This method assures the inclusion of bands of all symmetries necessary for describing the anisotropy of the heavy hole band with inclusion of the spin-orbit interaction⁷. We have adjusted the \mathbf{p} matrix elements, other than those known from the literature⁸, to obtain what we consider the best description of the band structure around the zone center of InAs and InSb. The parameters for InAs_{0.91}Sb_{0.09} were then derived by linear interpolation, except for the fundamental gap and the spin-orbit splitting for which measurements show a parabolic dependence⁹. The InAs_{0.91}Sb_{0.09} band structure around the zone center and the corresponding wave functions were then calculated. Optical matrix elements were deduced from these wave functions and the absorption was calculated from the standard formula¹⁰:

$$(1) \quad \alpha = \frac{q^2 \pi Z_0}{\sqrt{\epsilon_r} m_0^2 \omega} \sum_{\mathbf{k}, i, f} |(\mathbf{k}, f | \eta \cdot \mathbf{p} | \mathbf{k}, i)|^2 \delta(\epsilon_f(\mathbf{k}) - \epsilon_i(\mathbf{k}) - \hbar\omega) f_i(\mathbf{k})(1 - f_f(\mathbf{k}))$$

in which Z_0 is the vacuum impedance 377Ω , ϵ_r the relative permittivity and η the polarization direction of the electrical field. The sum is over all transitions from states in the initial band i to the final state band f , and f_i and f_f are the occupation probabilities of the states at room temperature. The calculation of this expression has fully taken into account the dependence on \mathbf{k} of all the terms in the sum. The absorption of a 800 nm thick layer of InAs_{0.91}Sb_{0.09} was found to be roughly 30% at 3.39 μm , corresponding to an absorption coefficient of 4606 cm^{-1} , as calculated by the $\mathbf{k}\cdot\mathbf{p}$ method. This result will be necessary for the estimation of lifetime by photoconductivity measurements.

As expected for small gap materials, the non parabolicity of the bands results in a rather linear shape at high energies, which justifies the need of this elaborate calculation. Note that in the case of a non-lattice matched material ($x \neq 9\%$), the influence of strain should be taken into account to obtain a similar level of agreement between theoretical predictions and experimental absorption spectra.

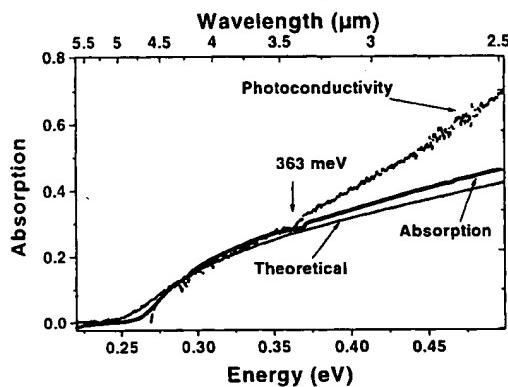


Figure 2. 800 nm thick InAs_{0.91}Sb_{0.09} absorption obtained from a normalized transmission experiment is in very good agreement with the theoretical simulations. The photoconductivity curve shown has been multiplied by the photon energy, yielding the product of the absorption and the photoconductivity gain G . A second band edge at 363 meV is attributed to the cap layer of InAlAsSb.

3.2. Spectral photoconductivity

Spectral photoconductivity provides an alternative way of measuring the band-to-band absorption. Moreover it leads to a more accurate determination of the band gap, because free carrier absorption does not contribute to the photocurrent. The

spectral photoconductivity measurements were carried out with the FTIR beam from the blackbody, focused by a parabolic mirror between the two TiPtAu contacts. The resulting spectra were normalized by the blackbody spectrum measured with a pyroelectric detector at a very low Michelson mirror speed, to ensure linearity of the detector's response. Since the responsivity is $R(A/W) = \alpha q G/h\nu$ with α the absorption and G the gain, the spectra were multiplied by $h\nu$, in order to be compared to the absorption obtained in the transmission experiment. The result is shown in figure 2.

The photoconductivity spectrum displays an additional absorption edge at 363 meV, above the energy gap of $\text{InAs}_{0.91}\text{Sb}_{0.09}$. This can be attributed to absorption in the InAlAsSb layers. A similar value was found by energy activation measurements, confirming this interpretation. The gap of 363 meV was then used for $\text{In}_{0.85}\text{Al}_{0.15}\text{As}_{0.9}\text{Sb}_{0.1}$ in the simulations (figure 1).

Note that it is a few tens of meV lower than the extrapolated value reported in⁵ at 0 K. Because the InAlAsSb feature is much stronger on photoconductivity spectra, in comparison with absorption spectra, it can be deduced that the photoconductive gain is greater for charges absorbed in the InAlAsSb layers, possibly due to charge separation in built-in electric fields. Thus the photocurrent generated in the thin InAlAsSb layers is magnified and made visible in the background signal of the 800 nm thick layer of $\text{InAs}_{0.91}\text{Sb}_{0.09}$. The InAlAsSb layers (15 times thinner than the InAsSb layer) are naturally less visible on the absorption spectrum. Even so, a slight increase in respect with the theoretical curve can be noticed in this region.

3.3. Photoluminescence and quaternary barrier gap determination

Photoluminescence at 300K was used as a further probe for the gap energy and as a qualitative indication of the lifetime. The excitation source was a 0.98 μm , broad angle laser diode operating at up to 60 mW averaged over a duty cycle of 50%. The sample was positioned at ~ 1 mm from the diode with an angle of incidence of the pump beam of roughly 60° . Since no focusing of the pump beam was used, the divergence of the laser diode led to an illuminated surface of a few mm^2 , corresponding to a carrier density always lower than 10^{16}cm^{-2} . The photoluminescence was collected by an f 0.8 Germanium lens that also served as a filter for the 0.98 μm pump. The collected beam was collimated into the FTIR spectrometer, and measured with a MCT detector. The spectrometer was operated in a step scan mode and the external lock-in amplifier was triggered at the diode frequency of 70 kHz. With a resolution of 32 cm^{-1} , the acquisition time for one spectrum was typically 10 minutes.

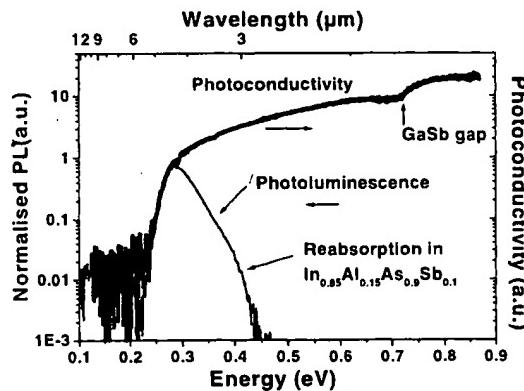


Figure 3. Photoluminescence and photoconductivity low energy edges superpose well, pointing to a band-to-band recombination mechanism. Reabsorption of PL from $\text{InAs}_{0.91}\text{Sb}_{0.09}$ in InAlAsSb is apparent on the high energy side of the PL peak. Photocurrent originating in the GaSb substrate is present above 700 meV, giving evidence for the thermal activation of the InAlAsSb barrier for holes. The photoconductivity spectrum is the same as the one shown on figure 2.

Figure 3 shows a good agreement of the low energy side of photoconductivity and PL spectra at 300K. This is a strong indication that our PL spectra are dominated by band-to-band recombination mechanism. In further support of this interpretation, we observe a high energy exponential decay corresponding to electronic temperatures of roughly 350 K. We have evidence that it is the excitation wavelength, rather than the power that is responsible for this electron heating. The change in electronic temperature was smaller than the experimental error (a few K) as the pump power was increased by 2 orders of magnitude, whereas a temperature as low as 325 K is obtained when operating at 1.55 μm . Ideally this experiment should be performed with a ~ 2.5 to 3 μm diode, unfortunately not commercially available. Figure 3 also shows a clear change in the exponential tail slope around 400 meV, two orders of magnitude below the peak maximum. We believe this to be due to the InAlAsSb layer whose gap energy of 363 meV was deduced from photoconductivity (figure 2). This shoulder in the PL spectrum results from reabsorption in InAlAsSb of high energy luminescence from $\text{InAs}_{0.91}\text{Sb}_{0.09}$.

3.4. Conclusion

This section demonstrates clearly that InAsSb lattice nearly lattice matched to a GaSb substrate is spectrally well suited for room temperature detection in the 3-5 atmospheric window.

4. LIFETIME MEASUREMENTS

4.1. Photoconductivity gain measurements

Photoconductivity gain measurements allowing lifetime calculation were carried out at room temperature. The photoresponse was measured under a field of 2.82 V/cm and a 3.39 μm HeNe laser beam. The illumination intensity distribution between the contacts was precisely deduced from the beam's gaussian shape, carefully mapped by a pyroelectric detector. The beam power was modulated by a polariser from 0 to 0.8 mW, and the photocurrent was deduced from a voltage lock-in measurement across a 50 ohm resistor (R_{charge}) mounted in series with the sample. The photoresponse is independent of the modulation frequency and linear with the illumination power, as can be seen from the inset of figure 5. This enables us to extract a photoconductive gain G related to the lifetime τ of the carriers by $G=\mu E \tau / l$, where μ is the carrier mobility, E the electric field and l the distance between contacts. The gain was found to be linear with the electric field up to 3 V/cm.

The expression of the lifetime is:

$$\tau = \frac{l}{\alpha} \left(1 + \frac{R_{\text{charge}} + R_{\text{wire}}}{R_{\text{sample}}^0} \right)^2 \left[\frac{\Delta V_{\text{signal}} / V_D}{\mu \eta} \right] \left(\frac{R_D A_D l^2 \cdot 1.2395}{R_{\text{charge}} A_E V_{\text{pd}}} \right) \quad (3)$$

ΔV_{signal} is the lock-in signal under illumination. The beam power is deduced from V_D : the voltage across the detector, its response R_D and surface A_D . The electrical resistances in series with the dark material resistance R_{sample}^0 are R_{wire} and R_{charge} . A_E is the illuminated surface between two contacts and l - the distance between contacts. η is a geometrical correction factor due to the non uniform energy density in the beam. The absorption α was taken equal to 30%, according to the experimental and theoretical results presented in the previous section.

Mobility is another key parameter. Its direct measurement by a Hall effect experiment was not possible for two reasons. First, the presence of the electron 2D gas, in addition to the 3D intrinsic carrier density in $\text{InAs}_{0.91}\text{Sb}_{0.09}$, complicated the interpretation of Hall measurements. The second reason is that the valence band InAlAsSb barrier was found to be thermally activated at room temperature. This fact was shown for instance by Hall measurements as a function of temperature on samples grown on p-type substrates. A photoconductivity signal at the GaSb gap energy (700 meV) (figure 3) gives further proof of the presence in $\text{InAs}_{0.91}\text{Sb}_{0.09}$ of charges photocreated in GaSb. Due to the difficulty of measuring the mobility, we have adopted the literature value for InAs: $30\,000\,\text{cm}^2/\text{V}\cdot\text{s}^3$. This choice may be subject to discussion and introduces an uncertainty in the lifetime calculated by equation (3).

It should be noted that the excitation source at $3.39\,\mu\text{m}$ was below the energy gap of GaSb. Consequently the totality of the photocurrent originates from $\text{InAs}_{0.91}\text{Sb}_{0.09}$. In addition, as the mobility of electrons is between 2 and 3 orders of magnitude greater than the mobility of holes, the photocurrent is due to electrons.

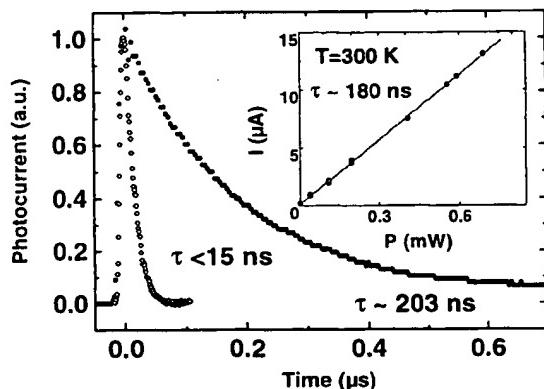


Figure 4. Time resolved photoconductivity measurements at 300 K using a $3.39\,\mu\text{m}$ OPO source. The effective lifetime is deduced from a monoexponential fit of the photocurrent decay. The resolution limit of the experiment set-up is less than 15 ns. The longest lifetime is ~ 200 ns ($x = 12.5\%$) and was obtained on the same sample used in the DC photoconductivity measurement shown in the inset of the figure. In that case, the lifetime is deduced from the slope of the curve.

4.2. Time resolved photoconductivity measurements

Time resolved photoconductivity measurements were performed at room temperature using a pulsed optical parametric oscillator (OPO) as pump source. This additional experiment is important to validate the results obtained by photoconductive gain measurements, especially because of the tentative value of the mobility. The OPO used LiNbO₃ as non linear crystal, and was tuned to 3.39 μm, the same wavelength as for gain measurements. The output power of the 15 ns pulses was 3 mJ per pulse; therefore a strong attenuation was needed to avoid high level photoexcitation and related Auger recombination. The electrical setting was identical to the one used in DC photoconductivity, and the lock-in amplifier was replaced by a rapid digital oscilloscope. Figure 5 shows the exponential decay of the photocurrent for two samples. The poor quality sample gives the resolution limit of the experimental set up : it is less than 15 ns. Lifetimes as high as 200 ns were obtained for good quality samples. For all samples the time resolved experiments were in very good agreement with lifetimes obtained by the photoconductive gain measurements.

4.3. Nature of the lifetime

The best lifetime was obtained for a slightly relaxed sample with 12.7% of Sb content. Therefore relatively low dislocation density is not an obstacle to high lifetime. The key parameters are essentially growth related and include the substrate temperature, the use of dimer or tetramer for As and Sb, and the relative fluxes of the V elements during deposition.

The poorest lifetime was obtained for a sample at x=14.4%. Auger mechanisms are clearly not possible at this level of excitation¹. Moreover, we found the calculated radiative lifetime in intrinsic InAs_{0.91}Sb_{0.09} to be 1.6 μs, significantly higher than 200 ns. Shockley-Read recombination seems most plausible. The value of 200 ns is the highest reported in the literature, to the best of our knowledge and points to an excellent material quality.

4.4. Carrier lifetime and mid IR-detection

The lifetime is a material parameter of great importance in a detection devices. It is a direct measurement of the generation-recombination rate in the detection layer. Generation-recombination being a source of noise, a long lifetime is highly advantageous. It can be shown, using the obtained value of 200 ns in InAsSb that the generation recombination noise is dominant over the Johnson noise at 300 K in photoconductive detectors, given an applied internal field of the order of 100 V/cm². At this temperature, It is also found to be substantially more than the noise induced by background radiation. All this shows the importance of a long lifetime, which in this case is limited by the quality of the InAsSb material.

5. PHOTOVOLTAIC DETECTOR

5.1. Detector structure

A photovoltaic p-i-n detector was grown, based on the structure shown in figure 1. The InAsSb detection layer was 1 μm thick and left undoped, to keep the generation recombination noise at its intrinsic level, given by the lifetime of 200 ns measured on the test samples. Barriers 1 and 2 were doped respectively P and N, at an extrinsic concentration of 1x10¹⁸cm⁻³. In addition to leaving InAsSb free of extrinsic doping, these barriers help to reduce the diffusion currents across the structure. The latter are an additional source of noise. The p-doped Al_{0.5}Ga_{0.5}Sb confines electrons and the n-doped In_{0.85}Al_{0.15}As_{0.9}Sb_{0.1} is aimed at stopping hole diffusion.

The photovoltaic detector consists of a 150X150μm mesa obtained by ion beam etching from the cap layer down to the GaSb buffer. The GaSb surface is then chemically treated in a H₂SO₄:H₂O₂:H₂O solution. The substrate is etched to allow illumination from the P side.

5.2. Detector characterization

Dark I(V) measurements are an important characterization technique. They give access first to the R₀A, that is the product of dark resistance and detector surface, and also to the ideality factor which is characteristic of the nature of the dominating noise inducing mechanism.

The value of R_0A is a direct probe of the noise level in the detector. In the case of a generation-recombination dominated noise regime, the R_0A is related to the previously measured lifetime by $R_0A = 2 \frac{kT\tau}{e^2 dn_i}$, where d is the thickness of the active InAsSb layer and n_i the intrinsic carrier density equal to $5 \times 10^{15} \text{ cm}^{-3}$ at 300 K. According to this formula, an R_0A of the order of $10 \Omega\text{cm}^2$ is expected.

The $I(V)$ characteristic of this detector is rectifying. It was measured as a function of temperature between 77 K and 290 K and yielded an R_0A of $0.127 \Omega\text{cm}^2$ at 290 K and $0.967 \Omega\text{cm}^2$ at 250 K. These values are substantially less than the R_0A previously calculated using a lifetime of 200 ns. This is a first indication that the generation-recombination noise might not be dominant.

The ideality factor was deduced from a linear fit of the logarithm of the $I(V)$ characteristic. This fit was carried out in a voltage range equivalent to less than half the value of the gap, to avoid the influence of possible tunneling mechanism. Values of the order of 1 have been measured between 120 and 290 K as can be seen from the inset of figure 5. This points to a diffusion dominated current.

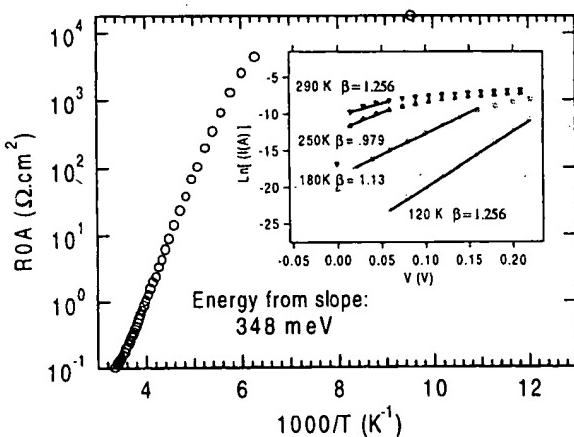


Figure 5. R_0A as a function of temperature, obtained from $I(V)$ measurements, such as those shown in the inset. An activation energy value of 343 meV is deduced from the slope of the curve. The linear fit of the logarithm of the $I(V)$, for voltage values equivalent to less than half the gap energy yield the ideality factor at temperatures ranging from 120 to 290 K.

Further evidence in support of a diffusion mechanism, limiting the noise of this detector is given by the variation of the R_0A with temperature, shown in figure 5. The R_0A is found to be exponentially activated at high temperature. The activation energy measured in figure 5 is of 349 meV. This energy is consistent with the gap energy of 363 meV of the quaternary InAlAsSb barrier, established in section 3 by photoluminescence and photoconductivity measurements on the test samples. This suggests that the diffusion of holes above the InAlAsSb barrier is the limiting mechanism in this device.

Assuming a quantum efficiency of the order of 30 %, based on the absorption measurements on the test samples, a detectivity of 2×10^9 Jones at 290 K and 7×10^9 Jones at 250 K is expected, based on the experimental values of R_0A . Integration of the spectral detectivity over the blackbody emission leads to a Noise Equivalent Temperature Difference NETD lower than 100 mK, for a $50 \times 50 \mu\text{m}$ pixel and at f/1. This is in the performance range of thermal detectors.

6. CONCLUSION

$\text{InAs}_{1-x}\text{Sb}_{0.07 < x < 14.4}$ material properties, critical for new optoelectronic applications in the 3 to 5 μm region have been thoroughly studied. The experimental absorption was found to be in very good agreement with the theoretical calculations, thus validating the model and the parameters used. The gap of InAsSb nearly lattice matched on GaSb was established to be very well suited for IR detection in the 3-5 μm range. Moreover, the gap of the InAlAsSb cap layer was measured, by photoluminescence and spectral photoconductivity experiments.

The high quality of the material was demonstrated with effective carrier lifetimes as high as 200 ns, confirmed by two different measurement techniques. This lifetime is likely to result from dominating Shockley-Read recombination

processes. Its high value is very promising for a InAsSb detector, in the case of dominant generation-recombination processes.

A photovoltaic p-i-n InAsSb detector was grown. Its performances at 300K are consistent with a limiting current of holes diffusing through the InAlAsSb barrier. The resulting R_0A decreasing exponentially with temperature, moderate Peltier cooling is of interest. The design can be improved by increasing the gap of the corresponding n-doped barrier for holes to achieve a generation recombination regime.

ACKNOWLEDGMENTS

The authors are grateful to J. P. Pocholle and J. M. Dupont for giving access to their OPO system, as well as M. Krakowski for providing us with the IR laser diodes used in PL measurements. We are deeply indebted to E. Rosenthaler, J. Nagle and F. Micheron for many valuable discussions.

REFERENCES

1. K. L. Vodopyanov, H. Graener, C. C. Phillips, and T. J. Tate, *Phys. Rev. B* **46**, 13194 (1992).
2. S. M. Newstead, R. A. A. Kubiak, and E. H. C. Parker, *J. of Crystal Growth* **81**, 49 (1987).
3. A. Rogalski and Z. Orman, *Infrared Phys.* **25**, 551-560 (1985).
4. A. G. Milnes and A. Y. Polyakov, *Solid State Electronics* **36**, 803-818 (1993).
5. G. W. Turner, M. J. Manfra, H. K. Choi, and M. K. Connors, *J. Cryst. Growth* **175/176**, 825-832 (1997).
6. P. S. Dutta and H. L. Bhat, *J. Appl. Phys.* **81**, 5821 (1997).
7. P. Y. Yu and M. Cardona, *Fundamentals of Semiconductors : Physics and Materials Properties* (Springer-Verlag, Berlin, 1996).
8. C. Hermann and C. Weisbuch, *Phys. Rev. B* **15**, 823 (1977).
9. O. Berozo and J. C. Woolley, in *11th International Conference on the Physics of Semiconductors*; Vol. 2 (PWN-Polish Scientific Publishers, Warszawa, 1972), p. 1420-25.
10. S. L. Chuang, *Physics of optoelectronic devices* (Wiley Interscience, New York, 1995).

L41 ANSWER 24 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 2001:340812 HCAPLUS
 DN 134:318460
 ED Entered STN: 14 May 2001
 TI Photovoltaic detector
 IN Berger, Vincent; Marcadet, Xavier; Rakovska, Ana
 PA Thomson CSF, Fr.

| | PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|------|---------------|------|----------|-----------------|----------|
| PI | FR 2800201 | A1 | 20010427 | FR 1999-13359 | 19991026 |
| | FR 2800201 | B1 | 20030704 | | |
| PRAI | FR 1999-13359 | | 19991026 | | |

AB The photovoltaic detector comprises a stack of ≥3 layers with a layer nonintentionally doped or weakly doped comprised between a p-doped layer and a n-doped layer, connection electrodes manufd. on the p- and n-doped layers, and a device for detection of current to the connection electrodes. In the detector the p-doped layer presents a barrier in the conduction band and does not present or partially presents a barrier in the valence band, the n-doped layer presents a barrier in the valence band and does not present or presents partially a barrier in the conduction band.

IT 25152-52-7, Aluminum antimonide 106603-88-7, Aluminum gallium antimonide 106603-91-2, Antimony indium arsenide (photovoltaic detector)

RN 25152-52-7 HCAPLUS

CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

RN 106603-88-7 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0-1:1:0-1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0 - 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

L41 ANSWER 16 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 2003:81886 DN 138:329159

ED Entered STN: 03 Feb 2003

TI Epitaxial ternary and quaternary III-V antimonide substrates

AU Mauk, Michael G.; Cox, Jeffrey A.; Sulima, Oleg V.; Datta, Sarbjit;

SO Proceedings - IEEE Lester Eastman Conference on High Performance Devices,

Newark, DE, United States, Aug. 6-8, 2002 (2002), 213-222 Publisher:

Institute of Electrical and Electronics Engineers, New York, N. Y.

CODEN: 69DMW8; ISBN: 0-7803-7478-9

AB Modified liq.-phase epitaxy (LPE) techniques can be adapted for the growth of relatively thick (50-500 μm) epitaxial layers of ternary and quaternary III-V antimonide alloys, including InAsSb, InGaSb, AlGaAsSb, InGaAsSb, and InAsSbP. These structures can function as virtual substrates with adjustable lattice consts. for epitaxy of various optoelectronic devices such as mid-IR photodiodes. A variety of substrate structures can be realized either by effecting gradual, continuous compositional grading of thick epilayers, or by growing multilayers with abrupt but incremental compositional changes between adjacent layers. Both approaches can be combined with selective removal of the seeding substrate and wafer bonding techniques. Low-defect alloy substrates with increased functionality, and with lattice consts. and bandgaps significantly different than available with binary compd. wafers (e.g., InAs or GaSb), appear feasible.

IT 12064-03-8

(LPE of ternary and quaternary III-V antimonide substrates)

RN 12064-03-8 HCAPLUS

CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |

IT 51680-21-8, Aluminum antimony gallium arsenide 106603-91-2

(LPE of ternary and quaternary III-V antimonide substrates)

RN 51680-21-8 HCAPLUS

CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

RN 107068-00-8 HCAPLUS

CN Antimony indium arsenide (Sb0.2InAs0.8) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0.8 | 7440-38-2 |
| Sb | 0.2 | 7440-36-0 |

RN 111706-54-8 HCAPLUS

CN Antimony indium arsenide (Sb0.15InAs0.85) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0.85 | 7440-38-2 |
| Sb | 0.15 | 7440-36-0 |

RN 125082-86-2 HCAPLUS

CN Antimony indium arsenide (Sb0.07InAs0.93) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0.93 | 7440-38-2 |
| Sb | 0.07 | 7440-36-0 |

L41 ANSWER 20 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 2001:713730 HCAPLUS

DN 135:264367

ED Entered STN: 28 Sep 2001

TI Multicolor **detector** for a semiconductor structure

IN Razeghi, Manijeh

PA Mp Technologies Llc, USA

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|------------------|-------|----------|-----------------|----------|
| ----- | ----- | ----- | ----- | ----- |
| PI WO 2001071813 | A1 | 20010927 | WO 2001-US5175 | 20010216 |
| US 6452242 | B1 | 20020917 | US 2000-534234 | 20000323 |

PRAI US 2000-534234 A 20000323

AB Multicolor **photodetectors** are described which comprise a heterostructure with a substrate, a lower contact layer, a single active region and an upper contact layer, each of the upper and lower contact layers having a bandgap; the active region having a bandgap different from the bandgap of the lower and upper contact layers; and the active region being lattice-matched to each of the upper and lower contact layers. The upper and lower contact layers are preferably formed from AlInSb or GaInSb. The active region is preferably formed from InAsSb, GaInSb, InBiSb, InTlSb, InPSb, InAsBiSb, or InPBiSb. The active region may also be a quantum well region. Methods for fabricating the **detectors** are also described.

IT 25152-52-7, Aluminum antimonide 106603-91-2, Indium arsenide antimonide

RL: DEV (Device component use); PEP (Physical, engineering or chemical process); PROC (Process); USES (Uses)
(multicolor **photodetectors**)

RN 25152-52-7 HCAPLUS

CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

L41 ANSWER 26 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 2000:737091 HCAPLUS
 DN 133:289974
 ED Entered STN: 19 Oct 2000
 TI Channel design to reduce impact ionization in heterostructure field-effect transistors
 IN Boos, J. Brad; Yang, Ming-jey; Bennett, Brian R.; Park, Doewon; Kruppa, Walter
 PA United States Dept. of the Navy, USA
 PATENT NO. KIND DATE APPLICATION NO. DATE
 ----- ----- ----- -----
 PI US 6133593 A 20001017 US 1999-358649 19990723
 PRAI US 1999-358649 19990723
 AB Heterostructure field-effect transistors (HFETs) and other electronic devices are fabricated from semiconductor layers to have reduced impact ionization. On to a 1st barrier layer there is added a unique 2nd sub-channel layer having high quality transport properties for reducing impact ionization. A 3rd barrier layer having a controlled thickness to permit electrons to tunnel through the layer to the sub-channel layer is added as a spacer for the 4th main channel layer. A 5th multilayer composite barrier layer is added which has at least a barrier layer in contact with the 4th channel layer and on top a 6th cap layer is applied. The device is completed by adding two ohmic contacts in a spaced apart relation on the 6th cap layer with a Schottky gate between them which is formed in contact with the 5th barrier layer. The 2nd sub-channel layer and the 4th main channel layers are made of materials which have the proper resp. **energy gaps** and ground state **energies** such that during use the transfer of hot electrons from the main channel into the sub-channel is made probable to reduce impact ionization in the main channel. In the preferred AlSb/InAs-based HFETs, the use of an Is InAs sub-channel layer under the main InAs channel improves the performance of the HEMTs particularly for gate lengths in the deep-submicron regime. The devices exhibit higher transconductance, lower output conductance, reduced gate leakage current, higher operating drain voltage, and improved frequency performance.

IT 25152-52-7 51680-21-8, Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As))
 (in fabrication of heterostructure field-effect transistors)

RN 25152-52-7 HCAPLUS
 CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

RN 51680-21-8 HCAPLUS
 CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 27 OF 66 HCPLUS COPYRIGHT 2005 ACS on STN

AN 2000:463690 HCAPLUS
DN 133:157370
ED Entered STN: 11 Jul 2000
TI Room temperature InAsSb photovoltaic midinfrared detector
AU Rakovska, A.; Berger, V.; Marcadet, X.; Vinter, B.; Glastre, G.;
Oksenhendler, T.; Kaplan, D.
CS Laboratoire Central de Recherches Thomson CSF, Domaine de Corbeville,
Orsay, 91404, Fr.
SO Applied Physics Letters (2000), 77(3), 397-399
CODEN: APPLAB; ISSN: 0003-6951
PB American Institute of Physics
AB An InAs0.91Sb0.09 p-i-n photovoltaic midinfrared detector grown by MBE
and operating at room temp. is presented. An R0A of $1.05 \Omega \text{ cm}^2$ at
250 K and $0.12 \Omega \text{ cm}^2$ at 295 K was achieved, resulting in a
detectivity of $4.5 \times 10^9 \text{ cm}\sqrt{\text{Hz/W}}$ at $3.39 \mu\text{m}$ and 250 K
The quality of the active region material ensures a sufficiently low
generation-recombination current. Room temp. performances are limited by
the diffusion of holes from the active region through the confining
barriers.

IT Optical detectors

IT 12064-03-8, Gallium antimonide
(room temp. InAsSb photovoltaic mid-IR detector)

RN 12064-03-8 HCAPLUS

CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|---------------------------|
|-----------|-------|---------------------------|

IT 110618-84-6 Antimony indium arsenide sb0.08inas0.92
Ga | 1 | 7440-55-3
Sb | 1 | 7440-36-0

IT 110619-84-6, Antimony indium arsenide sb0.09inas0.91
117944-40-8, Aluminum gallium antimonide al0.5ga0.5sb
RL: DEV (Device component use); PRP (Properties); USES (Uses)
(room temp. InAsSb photovoltaic mid-IR detector)

RN 110619-84-6 HCAPLUS

CN Antimony indium arsenide ($Sb_0.09InAs_0.91$) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
|-----------|-------|------------------------------|

| | | | | |
|----|--|------|--|-----------|
| In | | 1 | | 7440-74-6 |
| As | | 0.91 | | 7440-38-2 |
| Sb | | 0.09 | | 7440-36-0 |

RN 117944-40-8 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0.5:1:0.5)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
|-----------|-------|------------------------------|

| | | | | |
|----|--|-----|--|-----------|
| Ga | | 0.5 | | 7440-55-3 |
| Sb | | 1 | | 7440-36-0 |
| Al | | 0.5 | | 7429-90-5 |

L41 ANSWER 35 OF 66 HCPLUS COPYRIGHT 2005 ACS on STN

AN 1998:572332 HCPLUS

DN 129:209164

TI Interband quantum well cascade laser, with a blocking quantum well for improved quantum efficiency

IN Meyer, Jerry; Vurgaftman, Igor; Yang, Ruan Q.

PA United States Dept. of the Navy, USA

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|------------|------|------|-----------------|------|
|------------|------|------|-----------------|------|

PI US 5799026 A 19980825 US 1996-743433 19961101

PRAI US 1996-743433 19961101

AB Gain regions for interband quantum well lasers include an emitter region of semiconductor material having ≥ 1 conduction subband and ≥ 1 valence subband, these subbands being spaced apart by an **energy band-gap**; a collector region of semiconductor material having ≥ 1 conduction subband and ≥ 1 valence subband, these subbands spaced apart by an **energy band-gap**; a type-I or type-II active region; and a blocking quantum well region of semiconductor material between the active region and the collector region, for keeping electrons in the active region from tunnelling or scattering into the collector region, but allowing electrons in the highest valence subband in the active region to pass into the collector region. Cascade lasers formed from a stack of these gain regions, connected in series, optical cladding regions at opposing ends of the stack, and a voltage source for applying a bias voltage to the stack, and an optical cavity perpendicular to the stacking axis fabricated by cleaving or other means are also described.

IT 12064-03-8, Gallium antimonide 25152-52-7, Aluminum antimonide 106603-88-7, Aluminum gallium antimonide 106603-89-8, Antimony gallium arsenide ((Sb,As)Ga) 106603-91-2, Indium arsenide antimonide (interband quantum well cascade lasers with blocking quantum wells for improved quantum efficiency)

RN 12064-03-8 HCPLUS

CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |

RN 25152-52-7 HCPLUS

CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

RN 106603-88-7 HCPLUS

CN Aluminum, compd. with antimony and gallium (0-1:1:0-1)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0 - 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

RN 106603-89-8 HCPLUS

CN Antimony gallium arsenide ((Sb,As)Ga) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

RN 106603-91-2 HCPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

L41 ANSWER 36 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1998:559052 HCAPLUS

DN 129:142406

TI Infrared **detector** with an uncooled quantum well structure

IN Rosencher, Emmanuel; Vinter, Borge; Kaplan, Daniel; Micheron, Francois; Berger, Vincent

PA Thomson CSF S. A., Fr.

| | PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|----|-------------|------|----------|-----------------|----------|
| PI | FR 2757684 | A1 | 19980626 | FR 1996-15738 | 19961220 |
| | FR 2757684 | B1 | 19990326 | | |
| | US 5969375 | A | 19991019 | US 1997-991301 | 19971216 |
| | CA 2222855 | AA | 19980620 | CA 1997-2222855 | 19971217 |
| | JP 10190021 | A2 | 19980721 | JP 1997-351396 | 19971219 |

PRAI FR 1996-15738 A 19961220

AB The invention concerns a semiconductor quantum well structure contg. a low-gap semiconductor inserted between 2 large-gap semiconductor materials. The structure has a coupling grating placed between the wave to be **detected** (the plane of incidence) and the low-gap **detection** layer; in this configuration the **detection** layer can be very thin, typically on the order of 1000 Å, and leads to **detectivity** enhancement, limited by the dark current.

IT 12064-03-8, Gallium antimonide 25152-52-7, Aluminum antimonide 106603-88-7, Aluminum gallium antimonide 106603-91-2, Indium arsenide antimonide 111706-54-8, Antimony indium arsenide (Sb0.15InAs0.85)

(IR **detector** with uncooled semiconductor quantum well structure)

RN 12064-03-8 HCAPLUS

CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |

RN 25152-52-7 HCAPLUS

CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

RN 106603-88-7 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0-1:1:0-1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0 - 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

RN 111706-54-8 HCAPLUS

CN Antimony indium arsenide (Sb0.15InAs0.85) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0.85 | 7440-38-2 |
| Sb | 0.15 | 7440-36-0 |

L41 ANSWER 39 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1998:54492 DN 128:198068

TI Direct- and indirect-**energy-gap** dependence on Al concentration in

Al_xGal-xSb (x≤0.41)

AU Bignazzi, A.; Grilli, E.; Guzzi, M.; Bocchi, C.; Bosacchi, A.;

SO Physical Review B: Condensed Matter and Materials Physics (1998), 57(4), 2295-2301

AB The absorption spectra of Al_xGal-xSb alloys (x≤0.41), measured at low temps., were fitted including the contribution of direct and indirect transitions, taking into account the excitonic effects. This procedure yields accurate values of the energy of the direct Γ - Γ gap, $Eg\Gamma(x)$, as a function of the compn. and allows the detn. of the compn. dependence of the energy of the indirect Γ -L gap, $EgL(x)$. The dependence of the **energies** of the 2 **gaps** on the Al mole fraction for x≤0.41 is linear instead of quadratic, as reported so far. The extrapolation of this result to the whole x range (0≤x≤1) is discussed. A value of the Γ -L crossover concn. ($xc = 0.22$) significantly lower than the commonly accepted 1 ($xc = 0.35$) was obtained.

IT 107067-95-8 109117-63-7 111567-74-9 111567-75-0 115866-66-5 120922-66-9 120922-85-2 193092-01-2

(direct- and indirect-**energy-gap** dependence on Al

concn. in aluminum gallium arsenide [Al_xGal-xSb (x≤0.41)])

RN 107067-95-8 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0.25:1:0.75) (9CI) (CA INDEX

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0.75 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.25 | 7429-90-5 |

RN 109117-63-7 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0.11:1:0.89) (9CI) (CA INDEX

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0.89 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.11 | 7429-90-5 |

RN 111567-74-9 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0.2:1:0.8) (9CI) (CA INDEX

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0.8 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.2 | 7429-90-5 |

RN 111567-75-0 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0.3:1:0.7) (9CI) (CA INDEX

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0.7 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.3 | 7429-90-5 |

RN 115866-66-5 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0.15:1:0.85) (9CI) (CA INDEX

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0.85 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.15 | 7429-90-5 |

RN 120922-66-9 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0.05:1:0.95) (9CI) (CA INDEX
NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Ga | 0.95 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.05 | 7429-90-5 |

RN 120922-85-2 HCPLUS
CN Aluminum, compd. with antimony and gallium (0.35:1:0.65) (9CI) (CA INDEX
NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Ga | 0.65 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.35 | 7429-90-5 |

RN 193092-01-2 HCPLUS
CN Aluminum, compd. with antimony and gallium (0.41:1:0.59) (9CI) (CA INDEX
NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Ga | 0.59 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.41 | 7429-90-5 |

L41 ANSWER 42 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1996:543950 HCAPLUS

DN 125:183421

ED Entered STN: 12 Sep 1996

TI Semiconductor **photoelectric cathodes** and devices with the **cathodes**

IN Futahashi, Tokuaki

PA Hamamatsu Photonics Kk, Japan

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|---------------------|------|----------|-----------------|----------|
| JP 08153463 | A2 | 19960611 | JP 1994-293038 | 19941128 |
| JP 3537515 | B2 | 20040614 | | |
| PRAI JP 1994-293038 | | | 19941128 | |

CLASS

AB The **cathodes**, which generate electron upon light absorption, and emit the electron by accelerating through external field, contain p-type light-absorbing 1st semiconductor layers (e.g., Ge) on semiconductor substrates (e.g., GaAs), p-type 2nd semiconductor layers (e.g., GaAs), Schottky electrodes in Schottky contact with, and covering part or the whole of the 2nd semiconductor layers, and having openings, 3rd semiconductor (active) layers having smaller work function than that of the 2nd semiconductor layers, and formed in the openings, and semiconductors (e.g., ZnSe) (channel lattices) buried in the 2nd semiconductor layers and below the Schottky electrodes, and having wider bandgap than that of the 2nd semiconductor layers.

IT Cathodes

Photoelectric devices

(semiconductor **photoelec. cathodes** and devices with the **cathodes**)

IT 12064-03-8, Gallium antimonide 106603-88-7, Aluminum gallium antimonide 106603-91-2, Antimony Indium arsenide

RL: DEV (Device component use); USES (Uses)

(semiconductor **photoelec. cathodes** and devices with the **cathodes**)

RN 12064-03-8 HCAPLUS

CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |

RN 106603-88-7 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0-1:1:0-1) (9CI) (CA INDEX

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0 - 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

L41 ANSWER 44 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1996:543948 HCAPLUS

DN 125:183419

ED Entered STN: 12 Sep 1996

TI Semiconductor **photoelectric cathodes** and devices with the **cathodes**

IN Futahashi, Tokuaki

PA Hamamatsu Photonics Kk, Japan

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|-------------|------|----------|-----------------|----------|
| JP 08153461 | A2 | 19960611 | JP 1994-292977 | 19941128 |
| JP 3433537 | B2 | 20030804 | | |

PRAI JP 1994-292977 19941128

AB The **cathodes**, which generate electron upon light absorption, and emit the electron by accelerating through external field, contain p-type light-absorbing 1st semiconductor layers (e.g., Ge) on semiconductor substrates (e.g., GaAs), p-type 2nd semiconductor layers (e.g., GaAs), Schottky electrodes in Schottky contact with, and covering part or the whole of the 2nd semiconductor layers, and having openings, 3rd semiconductor (active) layers having smaller work function than that of the 2nd semiconductor layers, and formed in the openings, p-type semiconductors (e.g., ZnSe) (channel lattices) buried in the 2nd semiconductor layers and below the Schottky electrodes, and having greater impurity concn. than that of the 2nd semiconductor layers, and elec. conductors to apply voltage on the semiconductor parts.

ST semiconductor **photoelec cathode** device Schottky electrode; gallium arsenide germanium **photoelec cathode** device; zinc selenide **photoelec cathode** device; elec conductor **photoelec cathode** device

IT Cathodes

Photoelectric devices

(semiconductor **photoelec. cathodes** and devices with the **cathodes**)

IT 12064-03-8, Gallium antimonide 106603-88-7, Aluminum gallium antimonide 106603-91-2, Antimony indium arsenide
(semiconductor **photoelec. cathodes** and devices with the **cathodes**)

RN 12064-03-8 HCAPLUS

CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------|-----------------|
| | | | Registry Number |
| Ga | 1 | | 7440-55-3 |
| Sb | 1 | | 7440-36-0 |

RN 106603-88-7 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0-1:1:0-1) (9CI) (CA INDEX

| Component | Ratio | Component | |
|-----------|-------|-----------|-----------------|
| | | | Registry Number |
| Ga | 0 - 1 | | 7440-55-3 |
| Sb | 1 | | 7440-36-0 |
| Al | 0 - 1 | | 7429-90-5 |

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------|-----------------|
| | | | Registry Number |
| In | 1 | | 7440-74-6 |
| As | 0 - 1 | | 7440-38-2 |
| Sb | 0 - 1 | | 7440-36-0 |

L41 ANSWER 58 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1991:420465 HCAPLUS
 DN 115:20465
 ED Entered STN: 12 Jul 1991
 TI Semiconductor light-receiving device
 IN Ito, Kazuhiro
 PA Hitachi, Ltd., Japan
 SO Jpn. Kokai Tokkyo Koho, 5 pp.
 CODEN: JKXXAF

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|---------------------|------|----------|-----------------|----------|
| PI JP 02303073 | A2 | 19901217 | JP 1989-121519 | 19890517 |
| PRAI JP 1989-121519 | | 19890517 | | |

AB A 1st semiconductor light-receiving device comprises at least a 1st layer, on a light-incident side with respect to an AlGaSb-based amplifier layer, having a narrower band gap than the amplifier layer and a 2nd layer having a band gap in the order **wider** than the amplifier layer. A communication system device may comprises the 1st semiconductor light-receiving device. A 2nd semiconductor light-receiving device comprising a light-absorbing layer which generates an electron and hole by the light signal and a depletion layer, has a structure not to absorb the light in the outside of the depletion layer. The 2nd semiconductor light-receiving device may comprise a window layer on the light-incident side. The semiconductor light-receiving device gives a fast response time to a **wide** range of the signal wavelength, and has a low noise.

IT Photoelectric devices
 (semiconductor, light receiver, depletion films for)

IT 108915-80-6, Antimony indium arsenide (Sb0.1InAs0.9)
 134352-06-0, Aluminum antimony gallium (Al0.03SbGa0.97)
 RL: USES (Uses)
 (film, for semiconductor light-receiving device)

RN 108915-80-6 HCAPLUS

CN Antimony indium arsenide (Sb0.1InAs0.9) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0.9 | 7440-38-2 |
| Sb | 0.1 | 7440-36-0 |

RN 134352-06-0 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0.03:1:0.97) (9CI) (CA INDEX)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0.97 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.03 | 7429-90-5 |

IT 12064-03-8, Gallium antimonide
 (semiconductor light-receiving devices on)

RN 12064-03-8 HCAPLUS

CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |

L41 ANSWER 66 OF 66 HCPLUS COPYRIGHT 2005 ACS on STN

AN 1987:165855 HCPLUS
 DN 106:165855
 ED Entered STN: 15 May 1987
 TI Light-emitting semiconductor device
 IN Hayashi, Hideki
 PA Sumitomo Electric Industries, Ltd., Japan

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|-------------|------|----------|-----------------|----------|
| EP 201930 | A2 | 19861120 | EP 1986-106671 | 19860515 |
| EP 201930 | A3 | 19880120 | | |
| JP 62054489 | A2 | 19870310 | JP 1986-110175 | 19860514 |
| CA 1275485 | A1 | 19901023 | CA 1986-509128 | 19860514 |
| US 4815087 | A | 19890321 | US 1986-863609 | 19860515 |

PRAI JP 1985-104188 A 19850515

AB A high-efficiency light-emitting double-heterojunction semiconductor device is described which is stably operable at high speed and with low threshold current. The device comprises: a 1st layer of 1st cond. type; a 2nd layer of 2nd cond. type; an active layer of laminated semiconductor layers of the quantum well structure interposed between the above 2 semiconductor layers and having a narrower effective **energy band gap** than those of the 1st and 2nd layers; and a diffraction grating formed either in the 1st or the 2nd layer.

IT 12064-03-8, Gallium antimonide

RL: PRP (Properties)
 (light-emitting semiconductor device with **substrate** and active layer from)

IT 106603-88-7

RL: PRP (Properties)
 (light-emitting semiconductor device with active **layer** from)

RN 106603-88-7 HCPLUS

CN Aluminum, compd. with antimony and gallium (0-1:1:0-1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 0 - 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

IT 12064-03-8, Gallium antimonide

RL: PRP (Properties)
 (light-emitting semiconductor device with **substrate** and active layer from)

RN 12064-03-8 HCPLUS

CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |

L45 ANSWER 1 OF 3 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1977:181642 HCAPLUS

DN 86:181642

ED Entered STN: 12 May 1984

TI Semiconductor photoelectron emission device

IN Hara, Katsuo; Hagino, Minoru; Sukegawa, Tokuzo

PA Hamamatsu Terebi K. K., Japan

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|---------------------|---------------|------------|-----------------|-----------------------------|
| PI US 4015284 | A | 19770329 | US 1976-647761 | 19760109 <-- |
| | | US 3953880 | A 19760427 | US 1974-455231 19740327 <-- |
| PRAI US 1974-455231 | A3 | 19740327 | | |
| | JP 1973-72294 | A 19730628 | | |

CLASS

| PATENT NO. | CLASS | PATENT FAMILY CLASSIFICATION CODES |
|------------|-------|--|
| US 4015284 | IC | H01L029-161 |
| | INCL | 357016000 |
| US 4015284 | NCL | 257/010.000; 257/201.000; 313/542.000 <-- |
| US 3953880 | NCL | 257/010.000; 257/201.000; 257/441.000; 313/542.000 <-- |

AB A photoelectron emission device consists of a heterojunction of mixed crystals of ≥ 2 semiconductors. The crystals define a 1st region of direct transition type semiconductor and a 2nd region of an indirect transition type semiconductor having a forbidden band **wider** than that of the 1st region. This combination enables a high probability of electron transitions and increase of photoelectrons generated per unit of incident light. Also, only a small amt. of electrons are lost by recombination. In particular, p-GaSb which is a direct transition type semiconductor, a layer of intrinsic Ga_{1-x}Al_xSb ($x < 1$), a p-type layer of Ga_{1-y}Al_ySb ($0.4 < y < x$), an alkali metal or alkali metal-O activation layer on the opposite side of the Ga_{1-y}Al_ySb layer, and means for applying a bias voltage to the junctions comprise a photoelectron emission device. The Ga_{1-y}Al_ySb layer has a thickness equiv. of less than the electron diffusion length. The effective forbidden band of GaSb is 0.7-1.25 eV, and of Ga_{1-y}Al_ySb, it is 1.25-1.6 eV.

ST **photocathode** semiconductor; cathode photo semiconductor; gallium aluminum antimonide **photocathode**IT Cathodes
(photo-, from gallium antimonide and gallium aluminum antimonide)

IT 12064-03-8

RL: USES (Uses)

(photocathodes from gallium aluminum antimonide and)

IT 12064-03-8D, solid solns. with aluminum antimonide 25152-52-7D, solid solns. with gallium antimonide

RL: USES (Uses)

(photocathodes from gallium antimonide and)

L45 ANSWER 2 OF 3 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1975:556845 HCAPLUS

DN 83:156845

ED Entered STN: 12 May 1984

TI Group III-V compound photoemitters having a high quantum efficiency and long wavelength response

IN Schaefer, Donald L.

PA General Electric Co., USA

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|---------------------|------|----------|-----------------|--------------|
| PI US 3900865 | A | 19750819 | US 1971-206947 | 19711210 <-- |
| | | | US 1969-846155 | 19690730 <-- |
| PRAI US 1969-846155 | A3 | 19690730 | | |

AB A photoemitter with improved ir response consists of a semiconductive layer of a Group III-V compd. which has a bandgap equal to a desired photoelec. threshold, a 10-100 Å thick film of a 2nd III-V compd. which has a **wider** bandgap and contg. absorbed electropos. ions in an amt. sufficient to lower the surface work function to the desired photoelec. threshold. The structure has relatively high quantum efficiency. For example, a GaSb epitaxial layer is grown on a substrate, e.g. of optical quality borosilicate glass or GaAs. The layer is doped highly p-type, and a GaP layer is then deposited. This layer may be treated with both Cs and O to reduce the surface work function below a level achievable by Cs irradn. alone. The C bombardment and oxidn. step may occur simultaneously or sequentially. Structures involving other III-V compd. semiconductors are described, and the possible use of cesiation without oxidn. is included.

ST **photocathode** IIIA pnictide treatment; gallium pnictide **photocathode**, surface; phosphide gallium **photocathode** surface; antimonide gallium **photocathode** surface; cesiation oxidn semiconductor **photocathode**; cathode photo semiconductor pnictide

IT Group IIIA element pnictides

RL: USES (Uses)

(for cathode structure contg. layers of, treated with cesium)

IT Cathodes

(photo-, from Group III-V compd. layers treated with cesium)

IT 12063-98-8, uses and miscellaneous

RL: USES (Uses)

(photocathode structure contg. layers of, treated with cesium)

IT 12064-03-8

RL: USES (Uses)

(photocathode structures contg. layers of)

IT 7440-46-2, uses and miscellaneous 7782-44-7, uses and miscellaneous

RL: USES (Uses)

(photocathode structures from III-V compd. layers treated with)

L41 ANSWER 11 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 2003:697196 HCAPLUS

DN 139:216929

ED Entered STN: 05 Sep 2003

TI Monolithic **photovoltaic** energy conversion device

IN Wanlass, Mark W.; Mascarenhas, Angelo

PA Midwest Research Institute, USA

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|---------------|------|----------|-----------------|----------|
| WO 2003073517 | A1 | 20030904 | WO 2002-US5781 | 20020227 |
| WO 2003073518 | A1 | 20030904 | WO 2002-US5871 | 20020228 |
| US 2003160251 | A1 | 20030828 | US 2003-275123 | 20030310 |

PRAI WO 2002-US5781 A 20020227
 WO 2002-US5871 W 20020228

AB A multi-junction, monolithic, **photovoltaic** cell and device is provided for converting radiant energy to **photocurrent** and **photovoltage** with improved efficiency. The PV cell includes an array of subcells, i.e., active p/n junctions, grown on a compliant substrate, where the compliant substrate accommodates greater flexibility in matching lattice consts. to adjacent semiconductor material. The lattice matched semiconductor materials are selected with appropriate band-gaps to efficiently create **photovoltage** from a larger portion of the solar spectrum. Subcell strings from multiple PV cells are voltage matched to provide high output PV devices. A light emitting cell and device is also provided having monolithically grown red-yellow and green emission subcells and a mech. stacked blue emission subcell.

IT Photoelectric devices

IT 51680-21-8, Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As))
 (monolithic **photovoltaic** energy conversion device)

RN 51680-21-8 HCAPLUS

CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 15 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 2003:300300 HCAPLUS

DN 138:306822

ED Entered STN: 18 Apr 2003

TI **Wide-bandgap, lattice-mismatched window layer for a solar energy conversion device**

IN King, Richard Roland; Colter, Peter C.; Ermer, James H.; Haddad, Moran; Karam, Nasser H.

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|---------------------|------|----------|-----------------|----------|
| PI US 2003070707 | A1 | 20030417 | US 2001-976508 | 20011012 |
| | | | US 2003145884 | 20030131 |
| PRAI US 2001-976508 | A2 | 20011012 | | |

AB The invention is about **photovoltaic** cell or other optoelectronic device having a **wide-bandgap** semiconductor used in the window layer. This **wider** bandgap is achieved by using a semiconductor compn. that is not lattice-matched to the cell layer directly beneath it and/or to the growth substrate. The **wider** bandgap of the window layer increases the transmission of short wavelength light into the emitter and base layers of the **photovoltaic** cell. This in turn increases the current generation in the **photovoltaic** cell. Addnl., the **wider** bandgap of the lattice mismatched window layer inhibits minority carrier injection and recombination in the window layer.

IT 51680-21-8, Aluminum antimony gallium arsenide

RL: DEV (Device component use); USES (Uses)
 (wide-bandgap, lattice-mismatched window layer for
 solar **energy** conversion device)

RN 51680-21-8 HCAPLUS

CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| <hr/> | | | |
| Ga | 0 - 1 | 7440-55-3 | |
| As | 0 - 1 | 7440-38-2 | |
| Sb | 0 - 1 | 7440-36-0 | |
| Al | 0 - 1 | 7429-90-5 | |

L41 ANSWER 17 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 2002:946741 HCAPLUS
 DN 138:18611
 ED Entered STN: 13 Dec 2002
 TI Ultra-linear multi-channel field effect transistor
 IN Fahimulla, Ayub M.; Hier, Harry Stephen; Aina, Olaleye A.
 PA USA
 SO U.S. Pat. Appl. Publ., 18 pp., Cont.-in-part of U.S. Ser. No. 618,884.
 CODEN: USXXCO

DT Patent

LA English

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|---------------------|------|----------|-----------------|----------|
| PI US 2002185655 | A1 | 20021212 | US 2002-176787 | 20020624 |
| PRAI US 2000-618884 | A2 | 20000718 | | |

AB Alternate layers of **wide** band gap and narrow band gaps of different kinds of semiconductors were used to form multiple channels of a FET. The channels are doped or formed as 2-DEG/2-DHG in narrow band semiconductor by charge supply layer in the **wide** band gap semiconductor. The different kinds of semiconductors form heterojunctions to confine the electrons/holes in sep. thin spikes layers. A no. of spikes (3-10 nm thick) of different doped or 2-DEG/2-DHG concns. in various channels can result in overall electron concn. gradient such as a $1/x^3$ electron/hole concns. profile. Such an electron/hole concn. gradient can result in a linear variation of drain current with voltage to obtain a **wide** dynamic range.

IT 51680-21-8, Aluminum antimony gallium arsenide

RL: DEV (Device component use); PRP (Properties); TEM (Technical or engineered material use); USES (Uses)

(aluminum gallium indium arsenide phosphide **wide**
bandgap ultra-linear multi-channel field effect transistor)

RN 51680-21-8 HCAPLUS

CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | Registry Number |
|-----------|-------|-----------|-----------------|
| <hr/> | | | |
| Ga | 0 - 1 | | 7440-55-3 |
| As | 0 - 1 | | 7440-38-2 |
| Sb | 0 - 1 | | 7440-36-0 |
| Al | 0 - 1 | | 7429-90-5 |

L41 ANSWER 18 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 2002:117683 HCAPLUS
 DN 137:68432
 ED Entered STN: 14 Feb 2002
 TI Theoretical analysis of disorder effects on electronic and optical properties of the quaternary alloy $\text{Ga}_1\text{x}\text{Al}_x\text{As}_y\text{Sb}_{1-y}$
 AU Rabah, M.; Abid, H.; Bouhafs, B.; Aourag, H.
 CS Applied Materials Laboratory, University of Sidi Bel-Abbes, Sidi Bel-Abbes, 22000, Algeria
 SO Materials Chemistry and Physics (2002), 74(3), 328-335
 CODEN: MCHPDR; ISSN: 0254-0584
 PB Elsevier Science B.V.
 AB The effects of structural and chem. disorder on electronic and optical properties of GaAlAsSb quaternary alloy are studied on the basis of a modified virtual crystal approxn. calcd. within a simple tight-binding sp^3s^* theory, which incorporates compositional disorder as an effective potential. Using a minimal set of fitting parameters, we show that such an approach provides anal. results for calcd. energy gaps and bowing parameters. We show that the calcd. bowing parameter agrees reasonably well with exptl. data and other recent calcns. The essential features of structure and disorder-induced changes in electronic and optical structure are exhibited in the sp^3s^* results by two characterization parameters: the subband energy spacing and the d. of states. The changes in each of them are found to depend on the interrelated trends of structure and disorder effects.

IT 25152-52-7 51680-21-8, Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As))
 (theor. anal. of disorder effects on electronic and optical properties
 of quaternary alloy $\text{Ga}_1\text{x}\text{Al}_x\text{As}_y\text{Sb}_{1-y}$)

RN 25152-52-7 HCAPLUS

CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

RN 51680-21-8 HCAPLUS

CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 19 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 2001:793870 HCAPLUS
 DN 135:366150
 ED Entered STN: 01 Nov 2001
 TI Method for dyeing or labeling analytical samples with quantum dots or dendrimers containing fluorescent groups
 IN Iketaki, Yoshinori; Fujii, Masaaki; Omatsu, Takashige; Suzuki, Tomoo; Minakata, Makoto; Yamamoto, Kimitoshi; Nakaya, Kazuhiko
 PA Olympus Optical Co., Ltd., Japan; Nippon Roper K. K.; Foundation for Scientific Technology Promotion
 PATENT NO. KIND DATE APPLICATION NO. DATE
 ----- ----- ----- -----
 PI JP 2001305030 A2 20011031 JP 2000-118633 20000419
 PRAI JP 2000-118633 20000419
 AB The method gives samples which can be detected by double-resonance absorption microscope at an ultrahigh resoln.
 IT 25152-52-7 51680-21-8, Aluminum antimony gallium arsenide
 RL: ARG (Analytical reagent use); ANST (Analytical study); USES (Uses)
 (labeling agent; method for dyeing or labeling anal. samples with quantum dots or dendrimers contg. fluorescent groups)
 RN 25152-52-7 HCAPLUS
 CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

RN 51680-21-8 HCAPLUS
 CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 21 OF 66 HCPLUS COPYRIGHT 2005 ACS on STN

AN 2001:687711 HCPLUS
 DN 135:378399
 ED Entered STN: 20 Sep 2001
 TI Optoelectronic properties of **photodiodes** for the mid-and far-infrared based on the InAs/GaSb/AlSb materials family
 AU Fuchs, Frank; Buerkle, L.; Hamid, R.; Herres, N.; Pletschen, Wilfried; Sah, R. E.; Kiefer, Rudolf; Schmitz, J.
 CS Fraunhofer-Institut fuer Angewandte Festkoerperphysik (IAF), Freiburg, D-79108, Germany
 SO Proceedings of SPIE-The International Society for Optical Engineering (2001), 4288(Photodetectors: Materials and Devices VI), 171-182
 CODEN: PSISDG; ISSN: 0277-786X
 PB SPIE-The International Society for Optical Engineering
 DT Journal
 LA English
 CC 73-11 (Optical, Electron, and Mass Spectroscopy and Other Related Properties)
 AB The optoelectronic properties of short-period InAs/(GaIn)Sb superlattices (SLs) grown by MBE on GaSb substrates are discussed. The authors report on the optimization of the SL materials properties with special emphasis on the use for IR **detection** devices. The materials quality is evaluated by using high resoln. x-ray diffraction, at. force microscopy, and photoluminescence spectroscopy. In-plane magneto-transport studies were performed applying mobility spectrum anal. The SL diodes were analyzed performing std. electrooptical measurements. The observation of resonances in the I-V curves in the regime of Zener-tunneling due to Wannier-Stark localization opens a new tool for the elec. study of **photodiodes** with low **band gap energy**. The status of the processing technol. is reported demonstrating the feasibility for the fabrication of 256 X 256 focal plane arrays operating in the 8-to-12 μm atm. window. In addn., results are given for mid-IR SL-diodes, grown with lattice matched AlGaAsSb barriers instead in the binary InAs/GaSb SL system.
 IT Optical **detectors**
 (focal plane array; optoelectronic properties of **photodiodes** for mid-and far-IR based on InAs/GaSb/AlSb materials family)
 IT Atomic force microscopy
 Band gap
 IT 25152-52-7, Aluminum antimonide 51680-21-8, Aluminum gallium arsenide antimonide
 RL: DEV (Device component use); USES (Uses)
 (optoelectronic properties of **photodiodes** for mid-and far-IR based on InAs/GaSb/AlSb materials family)
 RN 25152-52-7 HCPLUS
 CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

 RN 51680-21-8 HCPLUS
 CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 23 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 2001:381860 HCAPLUS
 DN 135:124861
 ED Entered STN: 28 May 2001
 TI Advances in low-bandgap InAsSbP/InAs and GaInAsSb/GaSb thermophotovoltaics
 AU Mauk, Michael G.; Shellenbarger, Zane A.; Cox, Jeffrey A.; Tata, Anthony
 N.; Warden, Tammie G.; Dinetta, Louis C.; Mueller, Robert L.
 CS AstroPower, Inc., Newark, DE, 19716-2000, USA
 SO Conference Record of the IEEE Photovoltaic Specialists Conference (2000),
 28th, 1028-1031
 CODEN: CRCNDP; ISSN: 0160-8371
 PB Institute of Electrical and Electronics Engineers
 DT Journal
 LA English
 CC 52-2 (Electrochemical, Radiational, and Thermal Energy Technology)
 Section cross-reference(s): 76
 AB Thermophotovoltaic devices based on InGaAsSb and InAsSbP alloys made by
 liq.-phase epitaxy are described. These alloys can be readily grown as
 thick (>50 μm) layers to form "virtual" substrates. We are developing
 cell fabrication technologies to realize series-interconnected InGaAsSb
 and InAsSbP thermophotovoltaic cell arrays for high-voltage minimodules by
 transferring epitaxial device structures to insulating surrogate
 substrates.
 IT 51680-21-8, Aluminum gallium antimonide arsenide
 RL: DEV (Device component use); USES (Uses)
 (advances in low-bandgap InAsSbP/InAs and GaInAsSb/GaSb
 thermophotovoltaics)
 RN 51680-21-8 HCAPLUS
 CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 29 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 2000:270095 HCAPLUS
 DN 132:301803
 ED Entered STN: 26 Apr 2000
 TI Liquid-phase epitaxy of low-bandgap III-V antimonides for thermophotovoltaic devices
 AU Mauk, M. G.; Shellenbarger, Z. A.; Cox, J. A.; Sulima, O. V.; Bett, A. W.; Mueller, R. L.; Sims, P. E.; McNeely, J. B.; DiNetta, L. C.
 CS AstroPower, Inc., Newark, DE, 19716-2000, USA
 SO Journal of Crystal Growth (2000), 211(1-4), 189-193
 CODEN: JCRCGA; ISSN: 0022-0248
 PB Elsevier Science B.V.
 DT Journal
 LA English
 CC 76-5 (Electric Phenomena)
 Section cross-reference(s): 73, 75
 AB Liq.-phase epitaxial growth of low-bandgap III-V antimonides is developed for thermophotovoltaic and other optoelectronic device applications. Epitaxial layers of (Al,Ga)(As,Sb), (In,Ga)(As,Sb), and In(As,Sb,P) with thicknesses up to 200 μm can be grown in a single LPE step. TPV devices based on In(As,Sb,P) extend the spectral response to a wavelength of 3500 nm. These single-epilayer structures are compatible with post-growth zinc diffusion processes that produce high-performance TPV devices. Thick epitaxial layers are also conducive for epilayer film transfer to surrogate substrates and subsequent removal of the GaSb and InAs seeding substrate. An insulating surrogate substrate facilitates isolation schemes for monolithic series-interconnected TPV arrays, and a reflective substrate acting as a backside mirror is used to effect photon recycling.

IT 155702-91-3

RL: DEV (Device component use); FMU (Formation, unclassified); FORM (Formation, nonpreparative); USES (Uses)
 (liq.-phase epitaxy of low-bandgap III-V antimonides for thermophotovoltaic devices)

RN 155702-91-3 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0.67:1:0.33) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| <hr/> | | | |
| Ga | 0.33 | 7440-55-3 | |
| Sb | 1 | 7440-36-0 | |
| Al | 0.67 | 7429-90-5 | |

L41 ANSWER 30 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1999:727451 HCAPLUS

DN 131:315625

ED Entered STN: 17 Nov 1999

TI Indium-based alloy and infrared transducer using this alloy

IN Verie, Christian; Lorans, Dominique; Poirier, Michel

PA Sagem S. A., Fr.

| | PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|----|------------|------|----------|-----------------|----------|
| PI | FR 2775388 | A1 | 19990827 | FR 1998-2344 | 19980226 |
| | FR 2775388 | B1 | 20011207 | | |
| | EP 939447 | A1 | 19990901 | EP 1999-400446 | 19990224 |
| | US 6274882 | B1 | 20010814 | US 1999-258203 | 19990226 |

PRAI FR 1998-2344 A 19980226

AB The authors present an alloy designed for an IR transducer; it consists of $(In_{1-x})(As_{1-y}Sb_y)$ where $0 \leq x < 1$ and where x and y are each less than $1/2$. The transducer contains, on a substrate of GaSb or AlSb, an active layer of an alloy of compn. such that it is lattice matched to the substrate material.

ST detector IR indium antimony thallium arsenide; transducer IR indium antimony thallium arsenide

IT Optical detectors

Transducers

(IR; indium-based alloy with antimony, arsenic and thallium and use of alloy in IR transducer)

IT Passivation

IT 106603-91-2, Antimony indium arsenide ((Sb,As)In)

RL: DEV (Device component use); USES (Uses)

(active layer; indium-based alloy with antimony, arsenic and thallium and use of alloy in IR transducer)

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| In | 1 | 7440-74-6 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

IT 25152-52-7, Aluminum antimonide

RL: DEV (Device component use); USES (Uses)

(substrate; indium-based alloy with antimony, arsenic and thallium and use of alloy in IR transducer)

RN 25152-52-7 HCAPLUS

CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

L41 ANSWER 31 OF 66 HCPLUS COPYRIGHT 2005 ACS on STN

AN 1999:299862 HCPLUS
 DN 131:94422
 ED Entered STN: 17 May 1999
 TI Arsenic incorporation in molecular beam epitaxy (MBE) grown (AlGaIn)(AsSb)
 layers for 2.0-2.5 μm laser structures on GaSb substrates
 AU Simanowski, S.; Walther, M.; Schmitz, J.; Kiefer, R.; Herres, N.; Fuchs,
 F.; Maier, M.; Mermelstein, C.; Wagner, J.; Weimann, G.
 CS Fraunhofer-Institut fur Angewandte Festkorperphysik, Freiburg, D-79108,
 Germany
 SO Journal of Crystal Growth (1999), 201/202, 849-853
 CODEN: JCRCGA; ISSN: 0022-0248
 PB Elsevier Science B.V.
 DT Journal
 LA English
 CC 73-10 (Optical, Electron, and Mass Spectroscopy and Other Related
 Properties)
 Section cross-reference(s): 76
 AB The incorporation of As and In during MBE growth in (AlGaIn)/(AsSb) layers
 used for the fabrication of diode lasers in the 2.0-2.5 μm wavelength
 range was studied. The As content depends linearly on the beam equiv.
 pressure for As mole fractions between $y = 0.05$ and $y = 0.20$. Broad area
 AlGaAsSb/GaInAsSb single-quantum well laser diodes with quasi-cw output at
 room temp. at an emission wavelength of 2.03 μm and a threshold c.d. of
 515 A/cm² for 1370 μm long and 70 μm wide devices were fabricated.
 To shift the emission wavelength of the laser structures to longer
 wavelengths, the growth of lattice matched AlGaAsSb/GaInAsSb laser core
 structures with different In and As mole fractions in the quantum wells
 was studied.

IT 12064-03-8, Gallium antimonide (GaSb) 51680-21-8,
 Aluminum gallium arsenide antimonide
 RL: DEV (Device component use); USES (Uses)
 (arsenic incorporation in mol. beam epitaxy (MBE) grown (AlGaIn)(AsSb)
 layers for 2.0-2.5 μm laser structures on GaSb
 substrates)

RN 12064-03-8 HCPLUS
 CN Antimony, compd. with gallium (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |

RN 51680-21-8 HCPLUS
 CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 32 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1999:174832 HCAPLUS
 DN 130:273741
 ED Entered STN: 17 Mar 1999
 TI 2 μ m wave band InGaAsSb/AlGaAsSb wide stripe MQW diode laser
 AU Chen, Gaotting; Bai, Jingsong; Zhang, Yunmei; Geng, Jianxin; Fang, Zujie;
 Li, Aizhen; Zheng, Yanlan; Lin, Chun
 CS Shanghai Institute of Optics and Fine Mechanics, The Chinese Academy of
 Sciences, Shanghai, 201800, Peop. Rep. China
 SO Zhongguo Jiguang (1998), A25(12), 1069-1072
 CODEN: ZHJIDO; ISSN: 0258-7025
 PB Kexue Chubanshe
 DT Journal
 LA Chinese
 CC 73-10 (Optical, Electron, and Mass Spectroscopy and Other Related
 Properties)
 IT 51680-21-8P, Aluminum antimony gallium arsenide
 RL: DEV (Device component use); PRP (Properties); SPN (Synthetic
 preparation); PREP (Preparation); USES (Uses)
 (2 μ m wave band InGaAsSb/AlGaAsSb wide stripe MQW diode
 laser)
 RN 51680-21-8 HCAPLUS
 CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 33 OF 66 HCPLUS COPYRIGHT 2005 ACS on STN

AN 1999:166995 HCPLUS
 DN 130:360672
 ED Entered STN: 15 Mar 1999
 TI InAsSb light-emitting diodes for the **detection** of CO₂ ($\lambda=4.3 \mu\text{m}$)
 AU Popov, A. A.; Stepanov, M. V.; Sherstnev, V. V.; Yakovlev, Yu. P.
 CS A. F. Ioffe Physicotechnical Institute, Russian Academy of Sciences, St. Petersburg, Russia
 SO Technical Physics Letters (Translation of Pis'ma v Zhurnal Tekhnicheskoi Fiziki) (1998), 24(8), 596-598
 CODEN: TPLEED; ISSN: 1063-7850
 PB American Institute of Physics
 DT Journal
 LA English
 CC 79-6 (Inorganic Analytical Chemistry)
 Section cross-reference(s): 73, 76
 AB The main characteristics of room-temp. light-emitting diodes ($\lambda=4.3 \mu\text{m}$) based on InAsSbP/InAsSb/InAsSbP III-V semiconductor heterostructures with a variable-gap buffer layer are reported. An optical power P = 0.85 mW was achieved with a pulse length of ~5 μs and 1 kHz repetition frequency. Conditions for maximizing the power of the light-emitting diodes are indicated. An example is given of the use of these diodes to **detect** carbon dioxide using the 4.3 μm fundamental absorption band.
 IT 106603-91-2, Antimony indium arsenide ((Sb,As)In)
 RL: ARU (Analytical role, unclassified); DEV (Device component use); PRP (Properties); ANST (Analytical study); USES (Uses)
 (carbon dioxide **detection by absorption**
 spectroscopy with light-emitting diodes based on InAsSbP/InAsSb/InAsSbP III-V semiconductor heterostructures with variable-gap buffer layer)
 RN 106603-91-2 HCPLUS
 CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| In | 1 | 7440-74-6 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |

L41 ANSWER 34 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1998:750805 HCAPLUS
 DN 130:59579
 ED Entered STN: 27 Nov 1998
 TI **Energy bandgap** of $\text{Al}_x\text{Ga}_{1-x}\text{As}_{1-y}\text{Sb}_y$ and conduction band discontinuity of $\text{Al}_x\text{Ga}_{1-x}\text{As}_{1-y}\text{Sb}_y/\text{InAs}$ and $\text{Al}_x\text{Ga}_{1-x}\text{As}_{1-y}\text{Sb}_y/\text{InGaAs}$ heterostructures
 AU Anwar, A. F. M.; Webster, R. T.
 CS Electrical and Systems Engineering Dept., University of Connecticut, Storrs, CT, 06269-3157, USA
 SO Solid-State Electronics (1998), 42(11), 2101-2104
 CODEN: SSELAS; ISSN: 0038-1101
 PB Elsevier Science Ltd.
 DT Journal
 LA English
 CC 76-3 (Electric Phenomena)
 AB A technique to det. the conduction band discontinuity in any heterostructure and the resulting band alignment is presented. **Energy bandgaps** of the quaternary AlGaAsSb and conduction band discontinuity for lattice matched $\text{Al}_x\text{Ga}_{1-x}\text{As}_{1-y}/\text{InAs}$, $\text{Al}_x\text{Ga}_{1-x}\text{As}_{1-y}\text{Sb}_y/\text{In}0.8\text{Ga}0.2\text{As}$ and $\text{Al}_x\text{Ga}_{1-x}\text{As}_{1-y}\text{Sb}_y/\text{In}0.52\text{Ga}0.48\text{As}$ heterostructures are reported for varying Al and Sb mole fractions to demonstrate the method. $\text{Al}_x\text{Ga}_{1-x}\text{As}_{1-y}\text{Sb}_y/\text{InAs}$ changes from a type-II broken-gap alignment to type-II staggered alignment near an Al mole fraction of 0.15 followed by a change from type-II to type-I near an Al mole fraction of 0.9. No type-II broken-band alignments are obsd. in the other two lattice matched systems. The min. Al mole fraction required for type-I band alignment increases with increasing In mole fraction. It is shown that the quaternary bandgap becomes indirect for Al mole fractions greater than approx. 0.4 and the conduction band discontinuity is a linear function of the Al mole fraction for the lattice-matched systems.
 IT 107827-20-3, Gallium indium arsenide ($\text{Ga}0.2\text{In}0.8\text{As}$)
 PROC (Process)
 (lattice matching to aluminum antimony gallium arsenide; **energy bandgap** of $\text{Al}_x\text{Ga}_{1-x}\text{As}_{1-y}\text{Sb}_y$ and conduction band discontinuity of heterostructures)
 IT 51680-21-8, Aluminum antimony gallium arsenide
 ($\text{Al}0-1\text{Sb}0-1\text{Ga}0-1\text{As}0-1$)
 (**energy bandgap**; **energy bandgap**
 of $\text{Al}_x\text{Ga}_{1-x}\text{As}_{1-y}\text{Sb}_y$ and conduction band discontinuity of
 $\text{Al}_x\text{Ga}_{1-x}\text{As}_{1-y}\text{Sb}_y/\text{InAs}$ and $\text{Al}_x\text{Ga}_{1-x}\text{As}_{1-y}\text{Sb}_y/\text{InGaAs}$ heterostructures)
 RN 51680-21-8 HCAPLUS
 CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 37 OF 66 HCPLUS COPYRIGHT 2005 ACS on STN

AN 1998:327140 HCPLUS
 DN 129:47144
 ED Entered STN: 03 Jun 1998
 TI Effects of internal loss on power efficiency of mid-infrared
 InAs-GaInSb-AlSb quantum-well lasers and comparison with InAsSb lasers
 AU Le, H. Q.; Lin, C. H.; Murray, S. J.; Yang, R. Q.; Pei, S. S.
 CS MIT Lincoln Laboratory, Lexington, MA, 02173-9108, USA
 SO IEEE Journal of Quantum Electronics (1998), 34(6), 1016-1030
 CODEN: IEJQA7; ISSN: 0018-9197
 PB Institute of Electrical and Electronics Engineers
 DT Journal
 LA English
 CC 73-10 (Optical, Electron, and Mass Spectroscopy and Other Related
 Properties)
 Section cross-reference(s): 76
 AB Exptl. studies of the lasing efficiency of optically pumped 4- μm
 GaInSb-InAs-AlSb multiple-quantum-well (MQW) lasers that emitted >1-W peak
 power/facet at 80 K indicated that internal loss is the main factor that
 limits the power output. The internal loss coeff. and internal quantum
 efficiency were detd. by measuring the lasing efficiency vs. temp. for
 devices of different facet reflectivities and lengths. The internal loss
 coeff. increases from ~18 cm⁻¹ near 70 K to ~60-100 cm⁻¹ near
 180 K, while the internal quantum efficiency remained const. at ~47%
 (or ~67% with the correction for the finite absorption of the active
 region) from 70 to 130 K. The increase of internal loss and the decrease
 of external quantum efficiency vs. temp. were found very similar to those
 of double-heterostructure InAsSb-GaSb lasers and were similarly
 interpreted in terms of intervalence band carrier absorption.
 Extrapolation of power performance for improved devices with lower
 internal loss indicated that high-efficiency multi-watt quasi-CW output
 with a broad-area brightness of ~1 MW/cm²•sterad is possible.

IT 110619-84-6, Antimony indium arsenide Sb0.09InAs0.91
 RL: DEV (Device component use); PRP (Properties); USES (Uses)
 (valence band structure and mid-IR intervalence band **absorption**
 using k.p calcn.)

RN 110619-84-6 HCPLUS

CN Antimony indium arsenide (Sb0.09InAs0.91) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| <hr/> | | | |
| In | 1 | 7440-74-6 | |
| As | 0.91 | 7440-38-2 | |
| Sb | 0.09 | 7440-36-0 | |

L41 ANSWER 40 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1997:783757 HCAPLUS

DN 128:56413

ED Entered STN: 15 Dec 1997

TI Semiconductor **photocathode** and **photoemission** device using it

IN Nihashi, Tokuaki; Niigaki, Minoru

PA Hamamatsu Photonics K.K., Japan

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|---------------------|------|----------|-----------------|----------|
| EP 810621 | A1 | 19971203 | EP 1997-303615 | 19970528 |
| EP 810621 | B1 | 20030709 | | |
| R: DE, FR, GB | | | | |
| JP 09320457 | A2 | 19971212 | JP 1996-133789 | 19960528 |
| JP 3565529 | B2 | 20040915 | | |
| PRAI JP 1996-133789 | A | 19960528 | | |

CLASS

| PATENT NO. | CLASS | PATENT FAMILY CLASSIFICATION CODES |
|------------|-------|------------------------------------|
| EP 810621 | ICM | H01J001-34 |
| EP 810621 | ECLA | H01J001/34 |

AB Formed on a semiconductor substrate is a 1st semiconductor layer (light-absorbing layer) of p-type which has a 1st dopant concn. and generates an electron in response to incident light. Formed on the 1st semiconductor layer is a 2nd semiconductor layer (electron-transfer layer) of p-type having a 2nd dopant concn. lower than the 1st dopant concn. A contact layer forms a p-n junction with the 2nd semiconductor layer. A surface electrode is formed on and in ohmic contact with the contact layer. A 3rd semiconductor layer (activation layer) is formed within an opening in the contact layer on the surface of the 2nd semiconductor layer. Embedded in the 2nd semiconductor layer is a semiconductor section (channel grid) having a 3rd dopant concn. Thus, the quantum efficiency is improved, while structural pixel sepn. becomes unnecessary at an open area ratio of 100%, and signal modulation is enabled.

IT Photocathodes

(semiconductor **photocathode** and **photoemission** device using it)

IT 25152-52-7 106603-91-2, Antimony indium arsenide

RL: DEV (Device component use); USES (Uses)
(semiconductor **photocathode** contg.)

RN 25152-52-7 HCAPLUS

CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| Sb | 1 | 7440-36-0 | |
| Al | 1 | 7429-90-5 | |

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| In | 1 | 7440-74-6 | |
| As | 0 - 1 | 7440-38-2 | |
| Sb | 0 - 1 | 7440-36-0 | |

L41 ANSWER 41 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1997:267780 HCAPLUS
 DN 127:11712
 ED Entered STN: 26 Apr 1997
 TI "Universal" dependence of avalanche breakdown on band-structure: choosing materials for high-power devices
 AU Allam, Jeremy
 CS Hitachi Cambridge Lab., Hitachi Europe Limited, Japan
 SO Japanese Journal of Applied Physics, Part 1: Regular Papers, Short Notes & Review Papers (1997), 36(3B), 1529-1542
 CODEN: JAPNDE; ISSN: 0021-4922
 PB Japanese Journal of Applied Physics
 DT Journal
 LA English
 CC 76-3 (Electric Phenomena)
 AB A new simple phenomenol. relation between the breakdown voltage V_b and the band-structure in semiconductor junctions is presented. For narrow-gap semiconductors, V_b scales with the min. **energy gap** (E_g) as has been previously reported. However, for wide-gap materials including GaAs, InP, etc., V_b is linearly dependent on $\{E\}$, a Brillouin-zone-averaged **energy gap**. Values of $\{E\}$ are detd. from accurate quasi-particle band-structures for 25 tetrahedral semiconductors. The authors discuss the origin of this relation and the role of the ionization probability and electron-phonon scattering rate. The relation can be used to predict the breakdown voltage in semiconductors and semiconductor alloys.

IT 107067-94-7 110756-48-4, Aluminum gallium antimonide
 (Al_{0.28}Ga_{0.72}Sb)
 RL: PRP (Properties); TEM (Technical or engineered material use); USES (Uses)
 (phenomenol. relation between breakdown voltage and **energy gap** in semiconductors)

RN 107067-94-7 HCAPLUS
 CN Aluminum, compd. with antimony and gallium (0.06:1:0.94) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 0.94 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.06 | 7429-90-5 |

RN 110756-48-4 HCAPLUS
 CN Aluminum, compd. with antimony and gallium (0.28:1:0.72) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 0.72 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.28 | 7429-90-5 |

L41 ANSWER 46 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1995:170460 HCAPLUS
 DN 122:39160
 ED Entered STN: 08 Nov 1994
 TI Evaluation of various approximations used in the envelope-function method
 AU Meney, A. T.; Gonul, Besire; O'Reilly, E. P.
 CS Dept. of Physics, Univ. of Surrey, Surrey, GU2 5XH, UK
 SO Physical Review B: Condensed Matter and Materials Physics (1994), 50(15),
 10893-904
 CODEN: PRBMDO; ISSN: 0163-1829
 DT Journal
 LA English
 CC 65-3 (General Physical Chemistry)
 AB We investigate a no. of issues related to application of the envelope-function method in calcg. confined-state energies and subband structures in quantum-well structures. We first consider zone-center confined-state energies, and show how explicit elimination of spurious solns. from the envelope-function band structure leads to a slightly modified form of the std. result through which the conduction-**band** confined-state **energies** are calcd. by using a one-**band** model and an **energy**-dependent effective mass. We show that the effects of nonparabolicity can be predicted directly from the bulk band structure in an infinitely deep quantum well, and demonstrates how the bulk band structure can also be used to predict the errors in calcd. confinement energies in wells having finite depth. The correct choice of boundary conditions still remains controversial for calcn. of valence-subband structures by using the Luttinger-Kohn Hamiltonian. We compare the valence-band structure calcd. with the lowest conduction band included either explicitly or treated as a remote band, by using perturbation theory. We demonstrate that the boundary conditions derived by M. G. Burt (1992, 1994) and B. A. Foreman (1993-4) are correct. Finally, we compare the valence-band structure calcd. by using the 4 .times. 4 and 6 .times. 6 Luttinger-Kohn Hamiltonians. We show how the warping of the highest valence band is markedly different at both intermediate and large wave vectors when the spin-split-off band is included. Use of the axial model to calc. valence-band densities of states is therefore questionable with the 6 .times. 6 Hamiltonian. The calcd. warping is very sensitive to the values of the Luttinger .gamma. parameters used, indicating the importance of investing more effort to detn. these parameters accurately.

IT Energy level, **band** structure
 (confined-state **energies** and subband structures in quantum-well structures calcd. by using various approxns. in the envelope-function method)

IT 109224-96-6, Aluminum gallium antimonide (Al0.4Ga0.6Sb)
 (confined-state **energy** and subband structure in gallium indium antimonide arsenide-aluminum gallium antimonide quantum-well structure calcd. by using various approxns. in the envelope-function method)

RN 109224-96-6 HCAPLUS
 CN Aluminum, compd. with antimony and gallium (0.4:1:0.6) (9CI) (CA INDEX

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| Ga | 0.6 | 7440-55-3 | |
| Sb | 1 | 7440-36-0 | |
| Al | 0.4 | 7429-90-5 | |

L41 ANSWER 48 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1994:259113 HCAPLUS

DN 120:259113

ED Entered STN: 14 May 1994

TI N-type antimony-based strained layer superlattice semiconductor devices
and fabrication method

IN Hasenbergl, Thomas C.; Brown, April S.; Larson, Lawrence E.

PA Hughes Aircraft Co., USA

| | PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|----|-------------|------|----------|-----------------|----------|
| PI | EP 565054 | A2 | 19931013 | EP 1993-105687 | 19930406 |
| | EP 565054 | A3 | 19940727 | | |
| | JP 06061270 | A2 | 19940304 | JP 1993-83667 | 19930409 |
| | US 5420442 | A | 19950530 | US 1994-223373 | 19940405 |
| | US 5489549 | A | 19960206 | US 1994-223496 | 19940414 |

PRAI US 1992-866372 A 19920409

AB High-speed Group III-Sb materials are n-doped in a mol. beam epitaxy process by forming a superlattice with n-doped strained layers of a Group III-V compd. upon Group III-Sb base layers. The base layers have lower conduction **band energy** levels than the strained layers, and allow doping electrons from the strained layers to flow into the base layers. The base layers preferably comprise $Al_xGa_{1-x}Sb$, while the strained layers preferably comprise a binary or ternary compd. such as $Al_yGa_{1-y}As$ having a single Group V component, where x and y are each from 0 to 1.0. The strained layers can be n-doped with silicon or tin, which would produce p-type doping if added directly to the base layers.

IT 106603-88-7, Aluminum gallium antimonide $Al_0.1Ga_0.1Sb$

RL: DEV (Device component use); PEP (Physical, engineering or chemical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses)

(**base layer**, doping of, in fabrication of strained
layer superlattice semiconductor devices)

RN 106603-88-7 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0-1:1:0-1) (9CI) (CA INDEX
NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Ga | 0 - 1 | 7440-55-3 |
| Sb | 1, | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 49 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1993:507388 HCAPLUS

DN 119:107388

ED Entered STN: 04 Sep 1993

TI Semiconductor device with active quantum well gate

IN Goronkin, Herbert; Shen, Jun; Tehrani, Saied; Zhu, X. Theodore

PA Motorola, Inc., USA

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|---------------|------|----------|-----------------|----------|
| ----- | ---- | ----- | ----- | ----- |
| PI US 5221849 | A | 19930622 | US 1992-899439 | 19920616 |
| JP 06120519 | A2 | 19940428 | JP 1993-135053 | 19930514 |
| JP 3173631 | B2 | 20010604 | | |

PRAI US 1992-899439 A 19920616

AB A field-effect semiconductor device, having multiple vertically stacked channels sep'd. by independent gate electrodes, is provided where the channels are formed on a **wide** bandgap buffer layer and each channel is coupled to a drain electrode. Each channel is also coupled to a source electrode. The quantum well channels and quantum well gates are sep'd. from each other by barrier layers of a **wide** bandgap semiconductor material. Materials are specified.

IT 106603-88-7, Aluminum gallium antimonide ((Al,Ga)Sb)

RL: USES (Uses)

(wide band gap material, in semiconductor
device with active quantum well gate)

RN 106603-88-7 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0-1:1:0-1) (9CI) (CA INDEX
NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 0 - 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 50 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1993:506689 HCAPLUS

DN 119:106689

ED Entered STN: 04 Sep 1993

TI Interband near-infrared second-harmonic generation with very large $|\chi(2)(2\omega)|$ in aluminum antimonide/gallium antimonide-indium arsenide antimonide/aluminum antimonide asymmetric quantum wells

AU Scandolo, Sandro; Baldereschi, Alfonso; Capasso, Federico

CS Inst. Romand. Rech. Numer. Phys. Mater., PHB-Ecublens, Lausanne, CH-1015, Switz.

SO Applied Physics Letters (1993), 62(24), 3138-40

CODEN: APPLAB; ISSN: 0003-6951

AB The authors propose a novel steplike quantum-well structure for 2nd-harmonic generation with very large $|\chi(2)(2\omega)|$ in the near IR, based on interband doubly resonant transitions. The structure is engineered so as to maximize the 2nd-order susceptibility $\chi(2)(2\omega)$, which requires, in particular, avoiding too much overlap between the heavy-hole and the lowest electron envelope functions. The choice of a steplike asymmetry and of GaSb-InAsSb compds., instead of the conventional AlGaAs, leads to an enhancement of the 2nd-order susceptibility by ~30 times with respect to bulk GaAs, at pump wavelengths of 1.5 μm .

IT Energy level, band structure

(of gallium antimonide-indium antimonide arsenide quantum wells, second harmonic generation in relation to)

IT 106603-91-2, Antimony indium arsenide ((Sb,As)In)

(second harmonic generation in semiconductor quantum wells of gallium antimonide with)

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| In | 1 | 7440-74-6 | |
| As | 0 - 1 | 7440-38-2 | |
| Sb | 0 - 1 | 7440-36-0 | |

IT 25152-52-7, Aluminum antimonide

RL: USES (Uses)

(second harmonic generation in structure of gallium antimonide-indium antimonide arsenide quantum well with)

RN 25152-52-7 HCAPLUS

CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| Sb | 1 | 7440-36-0 | |
| Al | 1 | 7429-90-5 | |

L41 ANSWER 51 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1993:137271 HCAPLUS
 DN 118:137271
 ED Entered STN: 30 Mar 1993
 TI Energy levels in quantum wells of nonparabolic semiconductors
 AU Nag, B. R.; Mukhopadhyay, S.
 CS Inst. Radio Phys. Electron., Calcutta Univ., Calcutta, 700 009, India
 SO Physica Status Solidi B: Basic Research (1993), 175(1), 103-12
 CODEN: PSSBBD; ISSN: 0370-1972
 DT Journal
 LA English
 CC 76-3 (Electric Phenomena)
 AB Energy eigenvalues are given for quantum wells of the GaAs/(Ga,Al)As, GaInAs/(Al,In)As, and InAs/(Ga,Al)Sb systems, for widths ranging between 0.5 and 20 nm. The **energy band** nonparabolicity is shown to affect the values significantly particularly for wells with widths of ~2 nm. The InAs/(Ga,Al)Sb wells have the lowest energy levels with odd parity because of the neg. effective mass in the barrier layer for **energies** below the mid-gap **energy**. Expts. are suggested for the **detection** of these levels.

IT 106603-88-7

RL: USES (Uses)
 (**energy** levels in quantum-well structures of, with indium arsenide)

RN 106603-88-7 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0-1:1:0-1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 0 - 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 52 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1992:642018 HCAPLUS
 DN 117:242018
 ED Entered STN: 13 Dec 1992
 TI Temperature dependence of **band-gap energy** of aluminum gallium
 antimonide (Al_xGa_{1-x}Sb)
 AU Kitamura, Noboru; Yamamoto, Hidetsugu; Wada, Takao
 CS Dep. Electr. Eng., Suzuka Coll. Technol., Shiroko, 510-210, Japan
 SO Materials Letters (1992), 15(1-2), 89-91
 CODEN: MLETDJ; ISSN: 0167-577X
 DT Journal
 LA English
 CC 73-5 (Optical, Electron, and Mass Spectroscopy and Other Related
 Properties)
 AB Al_xGa_{1-x}Sb liq.-phase epitaxial layers were grown at 400°.
 Photoluminescence (PL) measurements at various temps. were carried out on
 the epitaxial layers. The **energy** of the **band** edge emission was
 evaluated from PL measurements. The exptl. results were well fitted with
 the formula Eg = E₀ - αT²/(T+β).
 ST luminescence aluminum gallium antimonide band gap
 IT Energy level, **band** structure
 (of aluminum gallium antimonide epitaxial layers)
 IT Luminescence
 (of aluminum gallium antimonide epitaxial layers, **band-**
 gap energy in relation to)
 IT Energy level, **band** structure
 (gap, of aluminum gallium antimonide)
 IT 106603-88-7, Aluminum gallium antimonide
 RL: PRP (Properties)
 (luminescence study of epitaxial layers of, **band-gap**
 energy in relation to)
 IT 106603-88-7, Aluminum gallium antimonide
 RL: PRP (Properties)
 (luminescence study of epitaxial layers of, **band-gap**
 energy in relation to)
 RN 106603-88-7 HCAPLUS
 CN Aluminum, compd. with antimony and gallium (0-1:1:0-1) (9CI) (CA INDEX
 NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 0 - 1 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 53 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1992:416944 HCAPLUS

DN 117:16944

ED Entered STN: 11 Jul 1992

TI Semiconductor planar avalanche **photodiode**

IN Tsuji, Masayoshi; Torikai, Toshitaka

PA NEC Corp., Japan

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|---------------------|------|----------|-----------------|----------|
| PI JP 04003474 | A2 | 19920108 | JP 1990-103809 | 19900419 |
| PRAI JP 1990-103809 | | 19900419 | | |

AB The **photodiode**, typically based on Group III-V semiconductors, comprises: (1) an intermediate and (2) an avalanche multiheterojunction layer, wherein (1) consists of (11) a 1st and (12) a 2nd semiconductor layer; (2) similarly consists of (21) and (22); the heterojunction interfaces of (1) and (2) are perpendicular to the substrate; (11) contacts with (21); the applied elec. field is parallel to the interfaces; and EA > EB > EC (EA, EB, EC = av. ionization energies of Group III elements in (21), (22), (11), resp.). The diode has a markedly improved avalanche yield and is suited for use in optical telecommunications.

IT Optical **detectors**

(semiconductor planar avalanche, contg. vertical heterojunction interfaces)

IT **Photoelectric** devices

(avalanche, semiconductor planar, contg. vertical heterojunction interfaces)

IT 25152-52-7, Aluminum antimonide (AlSb) **51680-21-8**,
Aluminum gallium arsenide antimonide ((Al,Ga)(As,Sb))

RL: PRP (Properties)

(semiconductor planar avalanche **photodiode** from)

RN 25152-52-7 HCAPLUS

CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

RN 51680-21-8 HCAPLUS

CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 54 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1992:201351 HCAPLUS
 DN 116:201351
 ED Entered STN: 16 May 1992
 TI Effects of ordering on the band structure of III-V semiconductors
 AU Teng, Dan; Shen, Jun; Newman, Kathie E.; Gu, Binglin
 CS Phys. Dep., Univ. Notre Dame, Notre Dame, IN, 46556, USA
 SO Journal of Physics and Chemistry of Solids (1991), 52(9), 1109-28
 CODEN: JPCSAW; ISSN: 0022-3697

DT Journal
 LA English
 CC 65-3 (General Physical Chemistry)

AB The band structures of five types of ordered compds. derived from parent zincblende alloys Al_{1-x}BxC and Al_{1-x}Dx have been detd. Included in this study are two novel x = 1/4, 3/4 derived structures, luzonite and famatinite, and three x = 1/2 structures, chalcopyrite and two 1 × 1 superlattices oriented along the (0,0,1) and (1,1,1) directions. The theory combines an empirical tight-binding model for III-V compds. and a valence force-field model of strain. Strain-induced tetragonal and internal distortions as well as the spin-orbit interaction cause a splitting of the top of the valence band. Trends in this splitting and the band-gap variation are studied for the 18 combinations of III-V elements. The Hopfield quasicubic crystal-field model is found to accurately describe this splitting for all chalcopyrite compds. But this model fails for several (0,0,1)- and (1,1,1)-superlattice compds. contg. large strain distortions. The extd. Hopfield crystal-field splitting parameters Δef is found to scale linearly with tetragonal distortion for common-anion compds. ABC₂, but follow curvilinearly internal distortion for common-cation compds. Strain and natural lineup energy modify the band gap significantly from that found in the virtual-crystal approxn. for the alloy. For the metastable alloy systems GaAs_{1-x}Sb_x and GaP_{1-x}Sb_x, the exptl. bowing of the band gap passes quite close to the results for the band gaps of the seven ordered structures.

IT Energy level, band structure

(of III-V semiconductors, effects of ordering on)

IT 107067-95-8 108915-73-7, Antimony gallium arsenide (Sb0.5GaAs0.5) 108915-78-2, Antimony indium arsenide (Sb0.5InAs0.5) 110832-09-2, Antimony gallium arsenide (Sb0.75GaAs0.25) 117944-40-8 118320-40-4, Antimony gallium arsenide (Sb0.25GaAs0.75) 118720-21-1 121871-91-8, Antimony indium arsenide (Sb0.75InAs0.25) 137806-99-6 139738-69-5, Antimony indium arsenide (Sb0.25InAs0.75)

RL: PRP (Properties)

(band structure of, effects of ordering on)

RN 107067-95-8 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0.25:1:0.75) (9CI) (CA INDEX)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| Ga | 0.75 | 7440-55-3 | |
| Sb | 1 | 7440-36-0 | |
| Al | 0.25 | 7429-90-5 | |

RN 108915-73-7 HCAPLUS

CN Antimony gallium arsenide (Sb0.5GaAs0.5) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| Ga | 1 | 7440-55-3 | |
| As | 0.5 | 7440-38-2 | |
| Sb | 0.5 | 7440-36-0 | |

RN 108915-78-2 HCPLUS
 CN Antimony indium arsenide (Sb0.5InAs0.5) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| In | 1 | 7440-74-6 |
| As | 0.5 | 7440-38-2 |
| Sb | 0.5 | 7440-36-0 |

RN 110832-09-2 HCPLUS
 CN Antimony gallium arsenide (Sb0.75GaAs0.25) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Ga | 1 | 7440-55-3 |
| As | 0.25 | 7440-38-2 |
| Sb | 0.75 | 7440-36-0 |

RN 117944-40-8 HCPLUS
 CN Aluminum, compd. with antimony and gallium (0.5:1:0.5) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Ga | 0.5 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.5 | 7429-90-5 |

RN 118320-40-4 HCPLUS
 CN Antimony gallium arsenide (Sb0.25GaAs0.75) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Ga | 1 | 7440-55-3 |
| As | 0.75 | 7440-38-2 |
| Sb | 0.25 | 7440-36-0 |

RN 118720-21-1 HCPLUS
 CN Antimony, compd. with gallium and indium (1:0.75:0.25) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| In | 0.25 | 7440-74-6 |
| Ga | 0.75 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |

RN 121871-91-8 HCPLUS
 CN Antimony indium arsenide (Sb0.75InAs0.25) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| In | 1 | 7440-74-6 |
| As | 0.25 | 7440-38-2 |
| Sb | 0.75 | 7440-36-0 |

RN 137806-99-6 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0.75:1:0.25) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Ga | 0.25 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.75 | 7429-90-5 |

RN 139738-69-5 HCAPLUS

CN Antimony indium arsenide (Sb0.25InAs0.75) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| In | 1 | 7440-74-6 |
| As | 0.75 | 7440-38-2 |
| Sb | 0.25 | 7440-36-0 |

L41 ANSWER 55 OF 66 HCPLUS COPYRIGHT 2005 ACS on STN

AN 1992:49576 HCPLUS
 DN 116:49576
 ED Entered STN: 08 Feb 1992
 TI Electron velocity in indium phosphide single-heterojunction quantum wells
 AU Bose, Devjani; Nag, B. R.
 CS Inst. Radio Phys. Electron., Calcutta, 700 009, India
 SO Semiconductor Science and Technology (1991), 6(12), 1135-40
 CODEN: SSTEET; ISSN: 0268-1242
 DT Journal
 LA English
 CC 76-3 (Electric Phenomena)
 AB The velocity-field characteristic is calcd. for a single-heterojunction InP well which may be realized by using $\text{Ga}_{x}\text{Al}_{1-x}\text{As}_{y}\text{Sb}_{1-y}$ as the barrier layer. The characteristic is detd. by the Monte Carlo method for the temps. of 300 K and 77 K. Characteristics of GaAs and $\text{Ga}_{0.47}\text{In}_{0.53}\text{As}$ are also computed and compared with earlier calcns. and the calcd. characteristics of InP. The peak electron velocity in InP is about the same as in $\text{Ga}_{0.47}\text{In}_{0.53}\text{As}$ or GaAs. The threshold field for intervalley transfer is, however, larger by a factor of 2.
 ST electron velocity indium phosphide quantum well
 IT Electron, conduction
 (velocity of, in indium phosphide quantum wells)
 IT Energy level, band structure
 (gap, of aluminum gallium antimonide arsenide, with lattice matched to indium phosphide)
 IT Semiconductor devices
 (quantum-well, indium phosphide, with barrier of aluminum antimonide arsenide, electron velocity in)
 IT 51680-21-8, Aluminum gallium antimonide arsenide
 RL: PRP (Properties)
 (band gap of, with lattice matched to indium phosphide)
 IT 122790-77-6, Aluminum antimony arsenide ($\text{AlSb}_{0.44}\text{As}_{0.56}$)
 RL: PRP (Properties)
 (electron velocity in indium phosphide quantum wells with barrier of)
 IT 22398-80-7, Indium phosphide, properties
 RL: PRP (Properties)
 (electron velocity in quantum wells of, with aluminum antimonide arsenide barrier)
 IT 1303-00-0, Gallium arsenide, uses 106097-59-0, Gallium indium arsenide ($\text{Ga}_{0.47}\text{In}_{0.53}\text{As}$)
 RL: USES (Uses)
 (electron velocity in, for different elec. fields)
 IT 51680-21-8, Aluminum gallium antimonide arsenide
 RL: PRP (Properties)
 (band gap of, with lattice matched to indium phosphide)
 RN 51680-21-8 HCPLUS
 CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 56 OF 66 HCPLUS COPYRIGHT 2005 ACS on STN

AN 1992:32161 HCPLUS
 DN 116:32161
 ED Entered STN: 24 Jan 1992
 TI Electrical characteristics and **energy band** offsets in gallium antimonide-gallium aluminum antimonide (n-GaSb-p-Ga_{0.83}Al_{0.17}Sb)
 AU Mebarki, M.
 CS Inst. Phys., Univ. Oran, Oran, Algeria
 SO Journal of Applied Physics (1991), 70(10, Pt. 1), 5420-2
 CODEN: JAPIAU; ISSN: 0021-8979
 DT Journal
 LA English
 CC 76-0 (Electric Phenomena)
 AB p,nGa_{1-x}Al_xSb/GaSb heterojunctions obtained by liq.-phase epitaxy were studied by capacitance-voltage characterization and spectral **photoresponse**. The band offsets of this system are $\Delta E_c = 0.14 \pm 0.03$ eV and $\Delta E_v = 0.07 \pm 0.03$ eV, in agreement with other work. This preliminary study is used to propose a variation law of the electron affinity as a function of the compn. x.
 ST **energy band** offset IIIA antimonide; gallium antimonide heterojunction band offset; aluminum gallium arsenide band offset
 IT Photoconductivity and Photoconduction
 (of gallium antimonide/gallium aluminum antimonide heterojunctions)
 IT Energy level, band structure
 (offset of, in gallium antimonide/gallium aluminum antimonide heterojunctions)
 IT Electric capacitance
 (potential relations with, of gallium antimonide/gallium aluminum antimonide heterojunctions)
 IT 12064-03-8, Gallium monoantimonide
 RL: USES (Uses)
 (**energy band** offsets in heterojunctions of, with gallium aluminum antimonide)
 IT 124696-85-1
 RL: USES (Uses)
 (**energy band** offsets in heterojunctions of, with gallium antimonide)
 IT 124696-85-1
 RL: USES (Uses)
 (**energy band** offsets in heterojunctions of, with gallium antimonide)
 RN 124696-85-1 HCPLUS
 CN Aluminum, compd. with antimony and gallium (0.17:1:0.83) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| Ga | 0.83 | 7440-55-3 | |
| Sb | 1 | 7440-36-0 | |
| Al | 0.17 | 7429-90-5 | |

L41 ANSWER 57 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1991:546285 HCAPLUS
 DN 115:146285
 ED Entered STN: 05 Oct 1991
 TI Optoelectronic devices
 IN Esaki, Leo; Ohno, Hideo; Mendez, Emilio Eugenio
 PA International Business Machines Corp., USA
 SO Eur. Pat. Appl., 10 pp.
 CODEN: EPXXDW

DT Patent

LA English

| | PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|------|----------------|------|----------|-----------------|----------|
| PI | EP 433542 | A2 | 19910626 | EP 1990-114315 | 19900726 |
| | EP 433542 | A3 | 19911227 | | |
| | EP 433542 | B1 | 19950705 | | |
| | US 5079601 | A | 19920107 | US 1989-453634 | 19891220 |
| | JP 03191579 | A2 | 19910821 | JP 1990-217256 | 19900820 |
| | JP 06054815 | B4 | 19940720 | | |
| PRAI | US 1989-453634 | A | 19891220 | | |

AB The title devices (e.g., light-emitting devices or **detectors**) comprise a quantum-well active region sandwiched between cladding electrode layers which may be sep'd. from the active region by tunneling regions and/or potential barriers, the band edges of the layers are offset so that, under an appropriate bias, ≥ 1 of the energy states (of the quantum-well layer) which emitting or absorption transitions occur lie in the bandgap of electrode and within an allowed region in the other electrode. Preferably, 1 of the states lies in the conduction band of 1 of the electrodes and the other lies in the valence band of the other electrode. The devices exhibit improved carrier injection efficiencies relative to prior art devices and may be tuned (e.g., using an applied magnetic field).

IT Electroluminescent devices

Optical **detectors**

(quantum-well, band edge offsets in)

IT 25152-52-7, Aluminum antimonide 51680-21-8, Aluminum gallium arsenide antimonide
 (optoelectronic devices contg.)

RN 25152-52-7 HCAPLUS

CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

RN 51680-21-8 HCAPLUS

CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 59 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1991:195004 HCAPLUS
 DN 114:195004
 ED Entered STN: 17 May 1991
 TI Optical characterization of silicon-doped indium arsenide antimonide grown on gallium arsenide and gallium arsenide-coated silicon by molecular-beam epitaxy
 AU Dobbelaere, W.; De Boeck, J.; Van Mieghem, P.; Mertens, R.; Borghs, G.
 CS Interuniv. Micro-Electron. Cent. VZW, Louvain, B-3001, Belg.
 SO Journal of Applied Physics (1991), 69(4), 2536-42
 CODEN: JAPIAU; ISSN: 0021-8979
 DT Journal
 LA English
 CC 73-2 (Optical, Electron, and Mass Spectroscopy and Other Related Properties)
 Section cross-reference(s): 65, 76
 AB Epitaxial layers of Si-doped InAs_{1-x}Sb_x ave been grown by MBE on GaAs and GaAs-coated Si substrates. The absorption coeff. was measured in the 3-12 μm wavelength range and the exptl. data was fit by using an anal. expression that was derived from the Kane band model. The fitted value of the Fermi level was used to calc. the electron concn. and the results were compared with doping levels obtained from SIMS and Hall measurements.
 IT Optical absorption
 (of indium antimonide arsenide silicon-doped epitaxial layers, Fermi level in relation to)
 IT Energy level, Fermi
 (of indium arsenide antimonide silicon-doped epitaxial layers, optical detn. of)
 IT 108915-77-1, Indium antimonide arsenide (InSb0.7As0.3)
 RL: PRP (Properties)
 (optical **absorption** of silicon-doped, Fermi level in relation to)
 RN 108915-77-1 HCAPLUS
 CN Antimony indium arsenide (Sb0.7InAs0.3) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------|-----------------|
| | | | Registry Number |
| <hr/> | | | |
| In | 1 | | 7440-74-6 |
| As | 0.3 | | 7440-38-2 |
| Sb | 0.7 | | 7440-36-0 |

L41 ANSWER 60 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1990:413968 HCAPLUS

DN 113:13968

TI Absorption edge of the variable-bandgap epitaxial layers of indium arsenide antimonide ($\text{InAs}_{1-x}\text{Sb}_x$, $x \leq 0.54$)

AU Zotova, N. V.; Losev, A. V.; Matveev, B. A.; Stus, N. M.; Talalakin, G.

SO Pis'ma v Zhurnal Tekhnicheskoi Fiziki (1990), 16(4), 76-80

CODEN: PZTFDD; ISSN: 0320-0116

LA Russian

AB An LPE method was used to grow, under conditions of high plasticity of the substrate (InAs), gradient layers $\text{InAs}_{1-x}\text{Sb}_x\text{Py}/\text{InAs}_{1-x}\text{Sb}_x$ with the bandgap E_g .gtorsim. 90 meV. The absorption edge of such structures was of the type typical for A3B5 variable-bandgap semiconductors. The absorption coeff. was detd. at 300 K for $h\nu = E_{g\min}$ as $\alpha_0 = 644 \text{ cm}^{-1}$ ($x = 0.54e$, $\alpha_0 = 1400 \text{ cm}^{-1}$ ($x = 0.15e$, and $\alpha_0 = 2000 \text{ cm}^{-1}$ ($x = 0.12$)).

IT Energy level, band structure
(gap, of indium arsenide antimonide epitaxial layers, optical absorption edge in relation to)

IT 111706-54-8, Antimony indium arsenide ($\text{Sb}_{0.15}\text{InAs}_{0.85}$)112802-08-1, Antimony indium arsenide ($\text{Sb}_{0.12}\text{InAs}_{0.88}$)127577-47-3, Antimony indium arsenide ($\text{Sb}_{0.54}\text{InAs}_{0.46}$)

RL: PRP (Properties)

(optical absorption edge of epitaxial)

RN 111706-54-8 HCAPLUS

CN Antimony indium arsenide ($\text{Sb}_{0.15}\text{InAs}_{0.85}$) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------|-----------------|
| | | | Registry Number |
| <hr/> | | | |
| In | 1 | | 7440-74-6 |
| As | 0.85 | | 7440-38-2 |
| Sb | 0.15 | | 7440-36-0 |

RN 112802-08-1 HCAPLUS

CN Antimony indium arsenide ($\text{Sb}_{0.12}\text{InAs}_{0.88}$) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------|-----------------|
| | | | Registry Number |
| <hr/> | | | |
| In | 1 | | 7440-74-6 |
| As | 0.88 | | 7440-38-2 |
| Sb | 0.12 | | 7440-36-0 |

RN 127577-47-3 HCAPLUS

CN Antimony indium arsenide ($\text{Sb}_{0.54}\text{InAs}_{0.46}$) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------|-----------------|
| | | | Registry Number |
| <hr/> | | | |
| In | 1 | | 7440-74-6 |
| As | 0.46 | | 7440-38-2 |
| Sb | 0.54 | | 7440-36-0 |

IT 127577-48-4, Antimony indium arsenide ($\text{Sb}_{0.54}\text{InAs}_{0.46-1}$)

(optical absorption edge of epitaxy of)

RN 127577-48-4 HCAPLUS

CN Antimony indium arsenide ($\text{Sb}_{0.54}\text{InAs}_{0.46-1}$) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|----------|-----------|-----------------|
| | | | Registry Number |
| <hr/> | | | |
| In | 1 | | 7440-74-6 |
| As | 0.46 - 1 | | 7440-38-2 |
| Sb | 0 - 0.54 | | 7440-36-0 |

L41 ANSWER 61 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1989:487047 HCAPLUS
 DN 111:87047
 ED Entered STN: 03 Sep 1989
 TI Avalanche multiplication in graded band gap structures
 AU Arutyunyan, V. M.; Petrosyan, S. G.
 CS Dep. Phys. Semicond. Dielectr., Yerevan State Univ., USSR
 SO Infrared Physics (1989), 29(2-4), 681-4
 CODEN: INFPAD; ISSN: 0020-0891
 DT Journal
 LA English
 CC 73-12 (Optical, Electron, and Mass Spectroscopy and Other Related Properties)
 Section cross-reference(s): 76
 AB Properties and peculiarities of avalanche multiplication in the p-i-n structures with the graded i-region are discussed. The grading of the band gap of semiconductors in the high field region of IR avalanche photoheterostructure governs the process of multiplication gain and improves noise characteristics of such **photodiodes**.
 ST avalanche multiplication graded band gap
 IT Semiconductor materials
 (avalanche multiplication in graded band gap structures contg.)
 IT Energy level, band structure
 (gap, avalanche multiplication in graded)
 IT 1303-00-0, Gallium arsenide, properties 37382-15-3, Aluminum gallium arsenide ((Al,Ga)As) **51680-21-8**, Aluminum gallium antimonide arsenide
 RL: PRP (Properties)
 (avalanche multiplication in graded **band gap** structures contg.)
 IT **51680-21-8**, Aluminum gallium antimonide arsenide
 RL: PRP (Properties)
 (avalanche multiplication in graded **band gap** structures contg.)
 RN 51680-21-8 HCAPLUS
 CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

L41 ANSWER 62 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1989:184365 HCAPLUS
 DN 110:184365
 ED Entered STN: 12 May 1989
 TI Super-high-speed transistors
 IN Muto, Shunichi
 PA Fujitsu Ltd., Japan

| PATENT NO. | KIND | DATE | APPLICATION NO. | DATE |
|--------------------|------|----------|-----------------|----------|
| PI JP 63229752 | A2 | 19880926 | JP 1987-62633 | 19870319 |
| PRAI JP 1987-62633 | | 19870319 | | |

AB A super-high-speed semiconductor device has an InAs_{1-x}Sb_x ($x \geq 0$) base layer and an InAsGaSb-contg. barrier layer in its collector side. The barrier layer is a high potential barrier, therefore, the device has high withstand voltage between base and collector layers and can be driven at super high speed, even at room temp. A hot-electron transistor having a nondoped GaSb substrate, a n+/n/n-InAs0.9Sb0.1 collector/base/emitter structure, and a barrier layer of (InAsSb)0.53(A10.5Ga0.5As)0.47 on the collector side had high thermal runaway resistance and high carrier mobility at room temp.

IT 108915-80-6, Antimony indium arsenide (Sb0.1InAs0.9)
 (base and collector and emitter layers of, of hot-electron transistor,
 large **energy gap** barrier layer in, for high thermal
 runaway resistance)

RN 108915-80-6 HCAPLUS

CN Antimony indium arsenide (Sb0.1InAs0.9) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| In | 1 | 7440-74-6 | |
| As | 0.9 | 7440-38-2 | |
| Sb | 0.1 | 7440-36-0 | |

IT 106603-91-2, Antimony indium arsenide ((Sb,As)In)
 (mixed crystal with aluminum gallium arsenide, collector barrier layer
 of, of hot-electron transistor)

RN 106603-91-2 HCAPLUS

CN Antimony indium arsenide ((Sb,As)In) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| In | 1 | 7440-74-6 | |
| As | 0 - 1 | 7440-38-2 | |
| Sb | 0 - 1 | 7440-36-0 | |

IT 117944-40-8, Aluminum gallium antimonide (Al0.5Ga0.5Sb)
 (mixed crystal with indium antimonide arsenide, collector barrier layer
 of, of hot-electron transistor)

RN 117944-40-8 HCAPLUS

CN Aluminum, compd. with antimony and gallium (0.5:1:0.5) (9CI) (CA INDEX

| Component | Ratio | Component | |
|-----------|-------|-----------------|--|
| | | Registry Number | |
| Ga | 0.5 | 7440-55-3 | |
| Sb | 1 | 7440-36-0 | |
| Al | 0.5 | 7429-90-5 | |

L41 ANSWER 63 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1989:16762 HCAPLUS
 DN 110:16762
 ED Entered STN: 06 Jan 1989
 TI Bond statistics and their influence on materials properties of III-V
quaternary alloys of type (AB)III(CD)V
 AU Ichimura, Masaya; Sasaki, Akio
 CS Dep. Electr. Eng., Kyoto Univ., Kyoto, 606, Japan
 SO Journal of Electronic Materials (1988), 17(4), 305-10
 CODEN: JECMA5; ISSN: 0361-5235
 DT Journal
 LA English
 CC 76-3 (Electric Phenomena)
 Section cross-reference(s): 65, 69
 AB The relative nos., or statistics, of bonds in the III-V quaternary alloy semiconductors of the type (AB)III(CD)V are derived by a thermodn. anal. The results are represented by single variable, ζ , which is zero for the completely random atom arrangement. The calcn. is carried out for the entire compn. range for nine quaternary alloy systems. On the basis of the results, the effects of bond statistics on materials properties are investigated. The effects of $\zeta \neq 0$ can be evaluated by a linear interpolation procedure. The nonrandom atom arrangement has only a small influence on properties such as lattice const. and **energy band gap**, if the alloy is grown through a quasiequil. process.
 IT Energy level, band structure
 (gap, of Group IIIA pnictide semiconductors)
 IT 51680-21-8
 RL: USES (Uses)
 (bond statistics and thermodn. properties of semiconductor)
 RN 51680-21-8 HCAPLUS
 CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Ga | 0 - 1 | 7440-55-3 |
| As | 0 - 1 | 7440-38-2 |
| Sb | 0 - 1 | 7440-36-0 |
| Al | 0 - 1 | 7429-90-5 |

IT 25152-52-7, Aluminum monoantimonide
 RL: USES (Uses)
 (semiconducting quaternary alloy contg., bond statistics of)
 RN 25152-52-7 HCAPLUS
 CN Aluminum, compd. with antimony (1:1) (9CI) (CA INDEX NAME)

| Component | Ratio | Component Registry Number |
|-----------|-------|------------------------------|
| Sb | 1 | 7440-36-0 |
| Al | 1 | 7429-90-5 |

L41 ANSWER 64 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1989:16622 HCAPLUS
 DN 110:16622
 ED Entered STN: 06 Jan 1989
 TI High pressure transport experiments in 3 dimensional systems
 AU Aulombard, Roger Louis; Kadri, Abderrahmane; Zitouni, Karima
 CS Groupe Etud. Semiconduct., USTL, Montpellier, 34060, Fr.
 SO NATO ASI Series, Series B: Physics (1987), 152(Opt. Prop. Narrow-Gap
 Low-Dimens. Struct.), 299-312
 CODEN: NABPDS; ISSN: 0258-1221
 DT Journal
 LA English
 CC 76-1 (Electric Phenomena)
 Section cross-reference(s): 65, 77
 AB The 3-dimensional system characteristics were studied as a function of pressure for semiconductors. Some available literature data are reviewed and discussed. The effect of the hydrostatic pressure on transport properties and band structure is described. Some new data for Al_{0.07}Ga_{0.93}Sb, InSb, InAs and Ga_{0.78}In_{0.22}Sb are presented. The de Haas-Shubnikov effect, magnetoresistance, current carriers mobility were measured as a function of pressure.
 IT De Haas-Shubnikov effect
 Energy level, **band** structure
 (in three dimensional semiconductors, pressure effect on)
 IT 108892-50-8, Aluminum gallium antimonide (Al_{0.07}Ga_{0.93}Sb)
 RL: PRP (Properties)
 (energy band structure for)
 RN 108892-50-8 HCAPLUS
 CN Aluminum, compd. with antimony and gallium (0.07:1:0.93) (9CI) (CA INDEX NAME)

| Component | Ratio | Component |
|-----------|-------|-----------------|
| | | Registry Number |
| <hr/> | | |
| Ga | 0.93 | 7440-55-3 |
| Sb | 1 | 7440-36-0 |
| Al | 0.07 | 7429-90-5 |

L41 ANSWER 65 OF 66 HCAPLUS COPYRIGHT 2005 ACS on STN

AN 1987:525061 HCAPLUS
 DN 107:125061
 ED Entered STN: 05 Oct 1987
 TI Band gaps and refractive indexes of aluminum gallium arsenide antimonide, gallium indium arsenide antimonide, and indium phosphide arsenide phosphide: key properties for a variety of the 2-4- μm optoelectronic device applications
 AU Adachi, Sadao
 CS Atsugi Electr. Commun. Lab., Nippon Telegr. and Teleph. Corp., Atsugi, 243-01, Japan
 SO Journal of Applied Physics (1987), 61(10), 4869-76
 CODEN: JAPIAU; ISSN: 0021-8979
 DT Journal
 LA English
 CC 76-1 (Electric Phenomena)
 Section cross-reference(s): 73
 AB Methods for calcn. the material parameters in compd. alloys are discussed, and the results of $\text{Al}_x\text{Ga}_{1-x}\text{As}_y\text{Sb}_{1-y}$, $\text{Ga}_x\text{In}_{1-x}\text{As}_y\text{Sb}_{1-y}$, and $\text{In}_x\text{P}_{1-x}\text{As}_y\text{Sb}_{1-y}$ quaternaries lattice matched to GaSb and InAs are presented. These quaternary systems may provide the basis for optoelectronic devices operating over the 2-4 μm range. The material parameters considered are: the lattice const., the lower direct- and indirect-gap energies, and the refractive index. The model used is based on an interpolation scheme, and the effects of compositional variations are properly taken into account in the calcns. Key properties of the material parameters for a variety of optoelectronic device applications are also discussed.
 IT Energy level, band structure
 (gap, of Group IIIA pnictide solid solns.)
 IT 51680-21-8
 RL: PRP (Properties)
 (band gap and refractive index of)
 RN 51680-21-8 HCAPLUS
 CN Aluminum antimony gallium arsenide ((Al,Ga)(Sb,As)) (9CI) (CA INDEX NAME)

| Component | Ratio | Component | |
|-----------|-------|-----------|-----------------|
| | | | Registry Number |
| Ga | 0 - 1 | | 7440-55-3 |
| As | 0 - 1 | | 7440-38-2 |
| Sb | 0 - 1 | | 7440-36-0 |
| Al | 0 - 1 | | 7429-90-5 |